

DEPARTMENT OF CIVIL ENGINEERING
IIT DELHI

LEC 3

STRUCTURAL HEALTH MONITORING: *SENSING TECHNOLOGIES*

Dr. Suresh Bhalla

Professor

Department of Civil Engineering

Indian Institute of Technology Delhi

Hauz Khas, New Delhi 110 016

Email: sbhalla@civil.iitd.ac.in Tel: (011) 2659-1040 Fax: (011) 2658-1117

Website: <http://web.iitd.ac.in/~sbhalla>

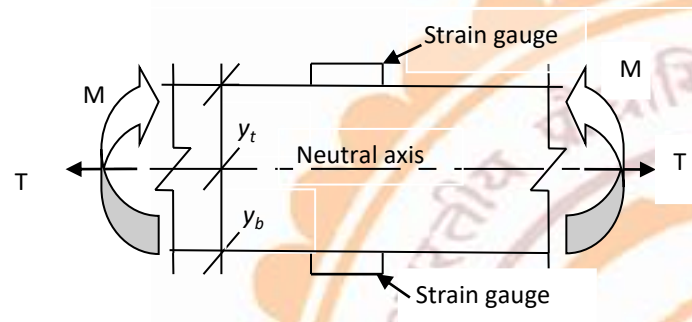
SENSING TECHNOLOGIES FOR STRUCTURAL MONITORING

CONVENTIONAL SENSORS (STATIC/ DYNAMIC)

- ** Electrical strain gauge (ESG) **
- ** Vibrating wire strain gauge (VWSG) **
- ** Accelerometers **

SENSORS BASED ON SMART MATERIALS

DETERMINATION OF AXIAL LOAD AND BENDING MOMENT THROUGH STRAIN MEASUREMENT



$$\epsilon_t = \frac{T}{AE} - \frac{My_t}{IE}$$

$$\epsilon_b = \frac{T}{AE} + \frac{My_b}{IE}$$

Tensile strain considered +ive here

where A is the cross sectional area, I the moment of inertia of the section and E the Young's modulus of elasticity.

Combining, the two equations:

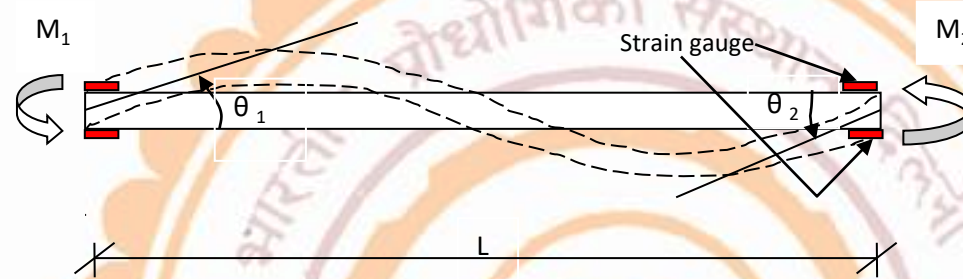
$$T = \frac{EA(\epsilon_b y_t + \epsilon_t y_b)}{(y_t + y_b)}$$

$$M = \frac{EI(\epsilon_b - \epsilon_t)}{(y_t + y_b)}$$

$y_t + y_b =$ TOTAL DEPTH OF THE SECTION UNDER CONSIDERATION

FOR STUDENTS OF CVL 864 IIT DELHI

MEASUREMENT OF MEMBER END ROTATIONS



$$\theta_1 = \left(\frac{L}{6EI} \right) \left[2(M_1 - M_1^F) - (M_2 - M_2^F) \right] \quad \theta_2 = \left(\frac{L}{6EI} \right) \left[2(M_2 - M_2^F) - (M_1 - M_1^F) \right]$$

From elementary slop-deflection equations

where M_1^F and M_2^F represent the fixed ended moments, resulting from the member loads. It is assumed here that there is no relative displacements between the two member ends (i.e columns are inextensible).

SENSING TECHNOLOGIES FOR STRUCTURAL MONITORING

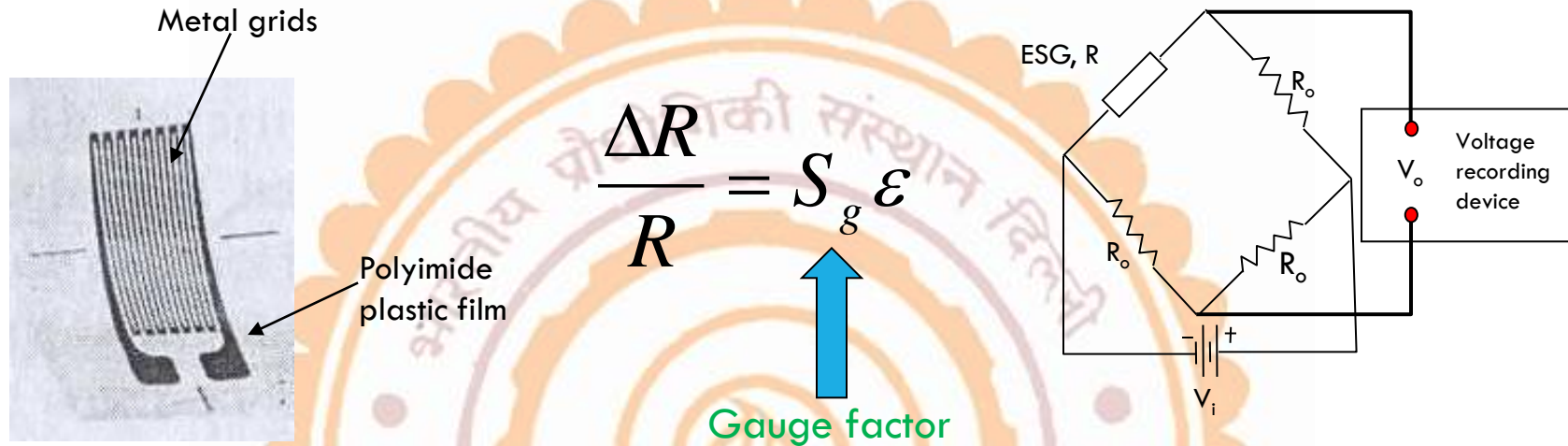
CONVENTIONAL SENSORS (STATIC/ DYNAMIC)

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SENSORS BASED ON SMART MATERIALS

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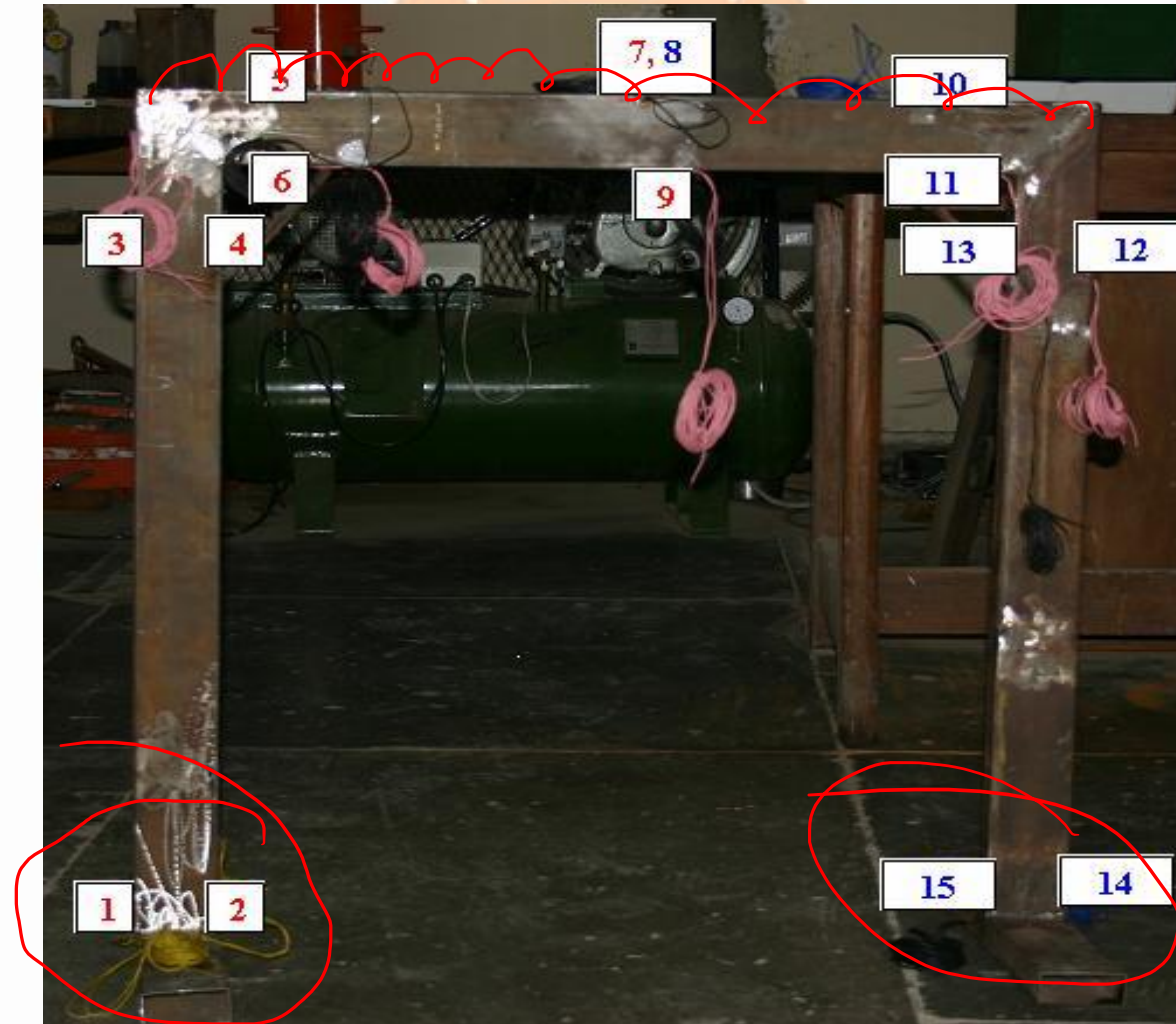
ELECTRICAL STRAIN GAUGE (ESG)



KEY ADVANTAGES

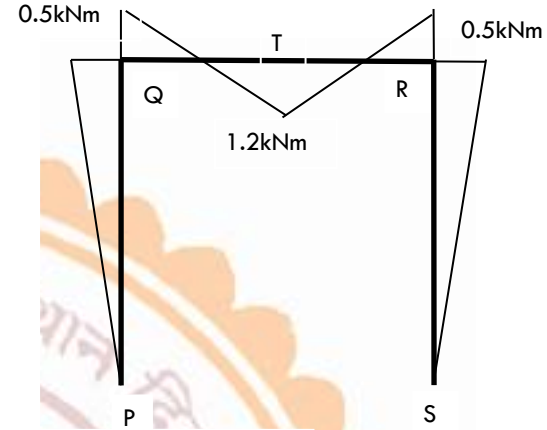
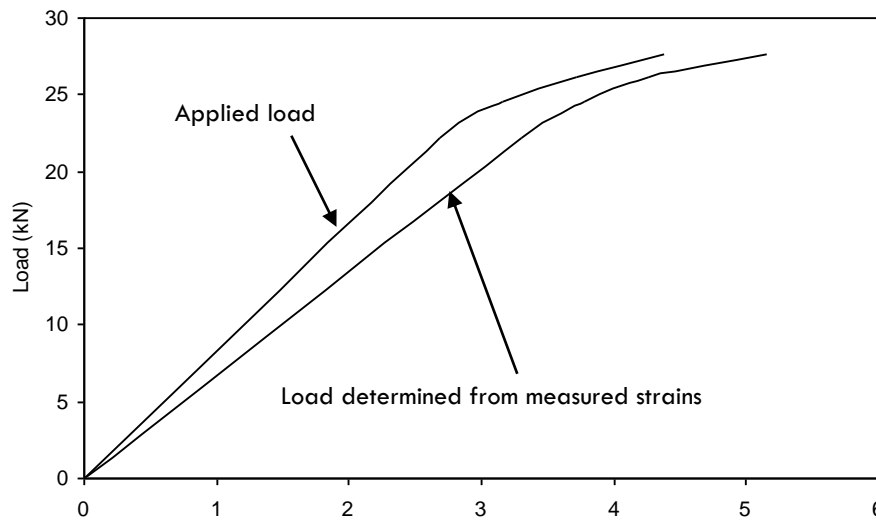
- * Low- cost (~ Rs 100)
- * Easy to install and handle
- * Simple wheat stone bridge circuit coupled with amplification circuit sufficient for measurement

MONITORING OF STEEL FRAMES

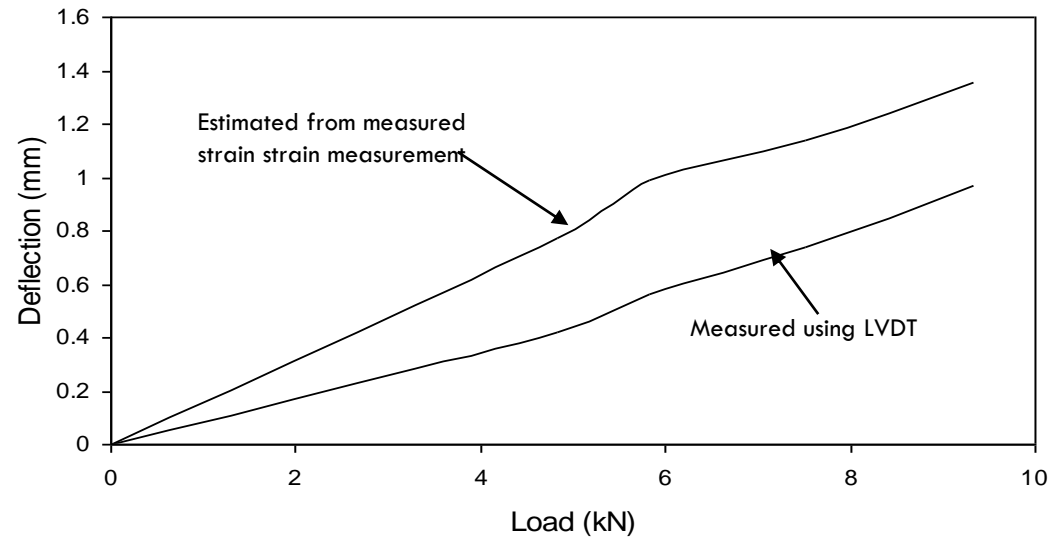


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Load Estimation



Bending moments

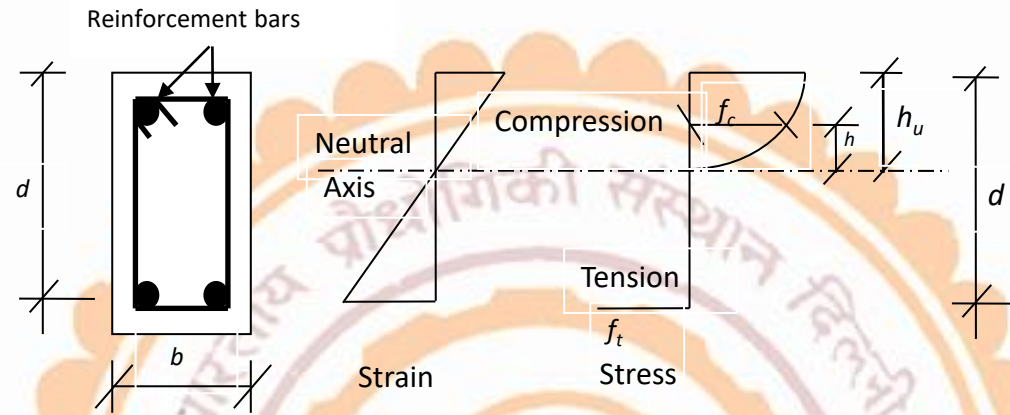


Deflections

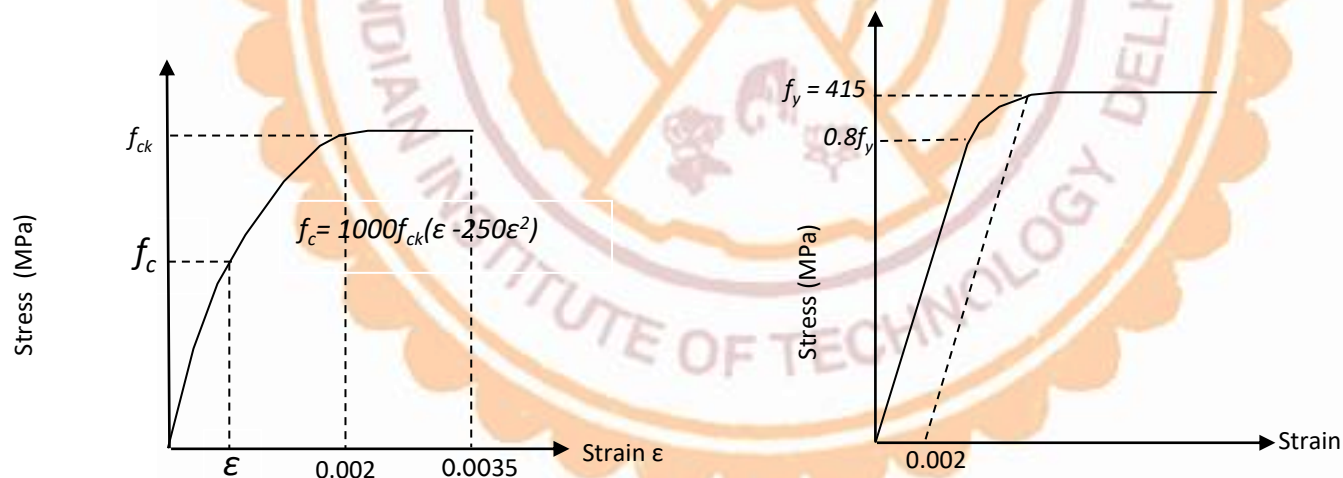
By double integration of (M/EI) curve

$$\frac{d^2 y}{dx^2} = \frac{M}{EI}$$

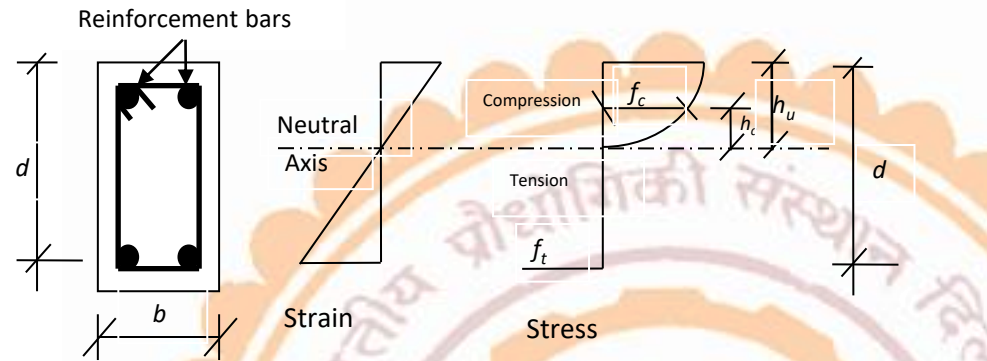
MONITORING OF RC STRUCTURES



We need to measure strain distribution along the section, use the available stress-strain relations of concrete and steel to determine internal moment and axial force.



MONITORING OF RC STRUCTURES

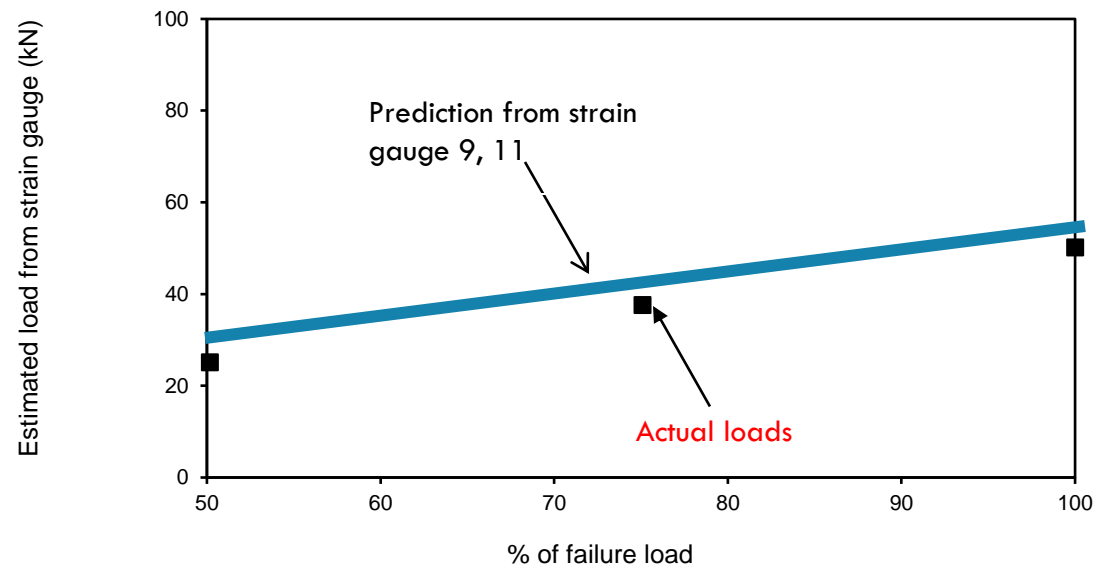
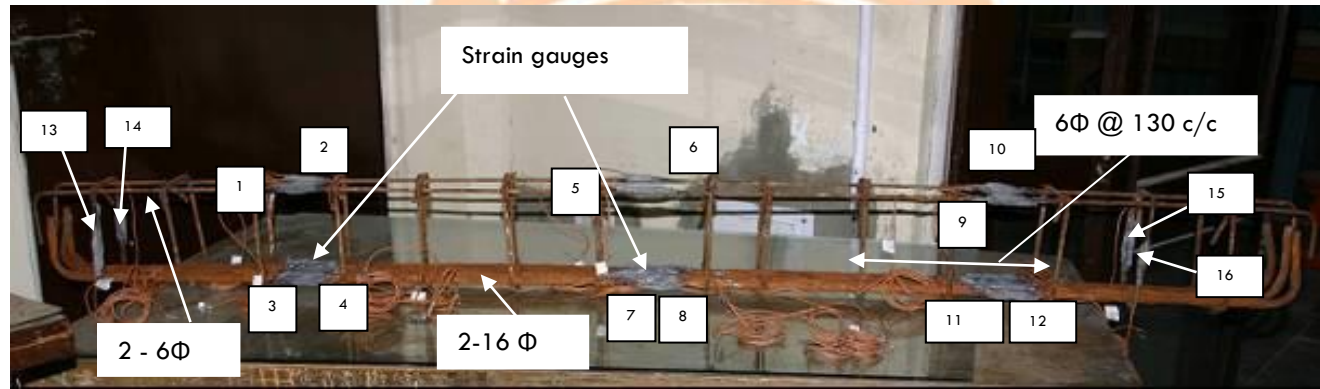


$$C = \int_{h=0}^{h=h_u} f_c b dh \quad h_c = \frac{1}{C} \int_{h=0}^{h=h_u} f_c b h dh$$

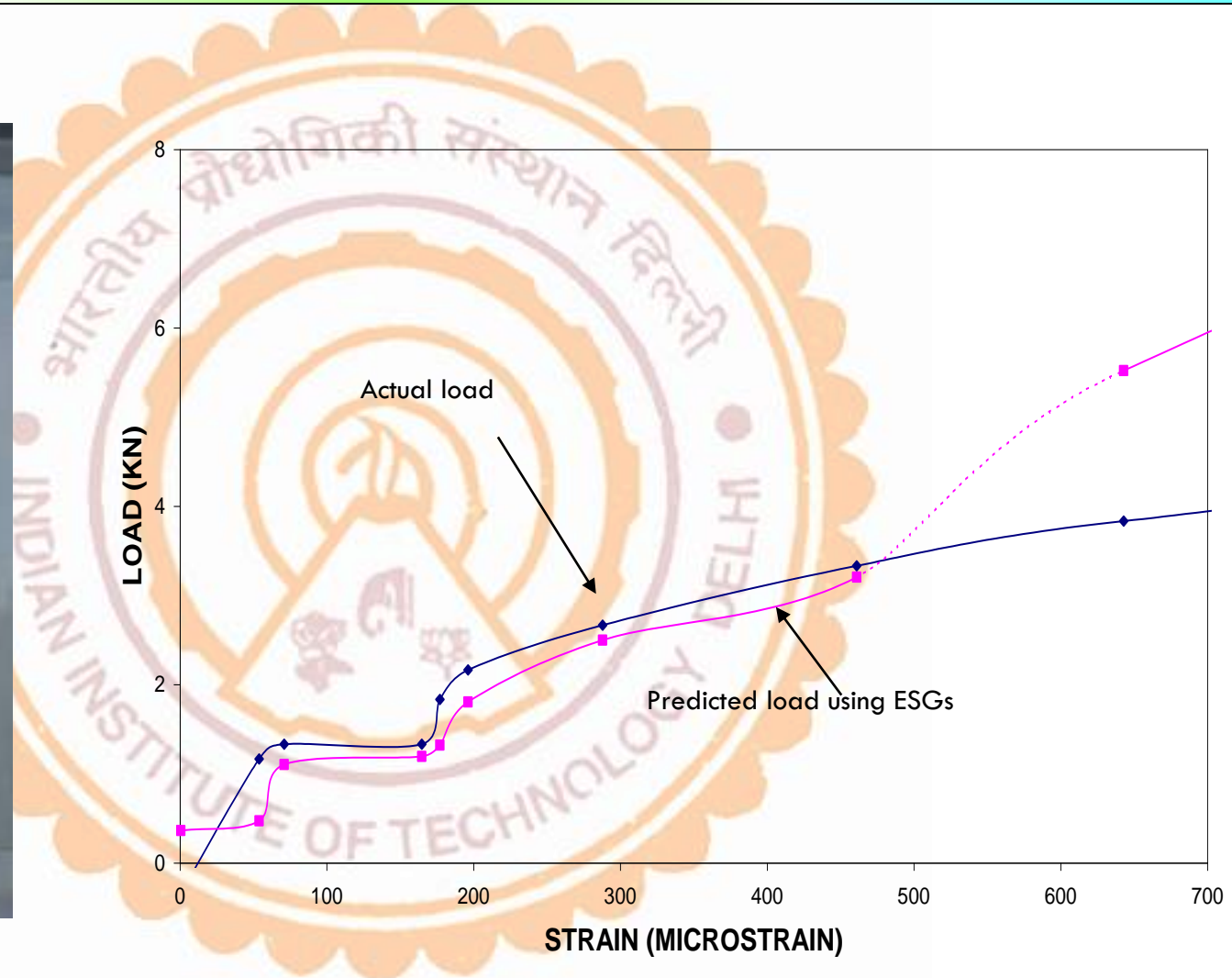
The internal bending moment at the section can be obtained by taking the moment of the compressive stresses about the centroid of the tensile stresses (bottom reinforcement) as

$$M = C(d - h_u + h_c)$$

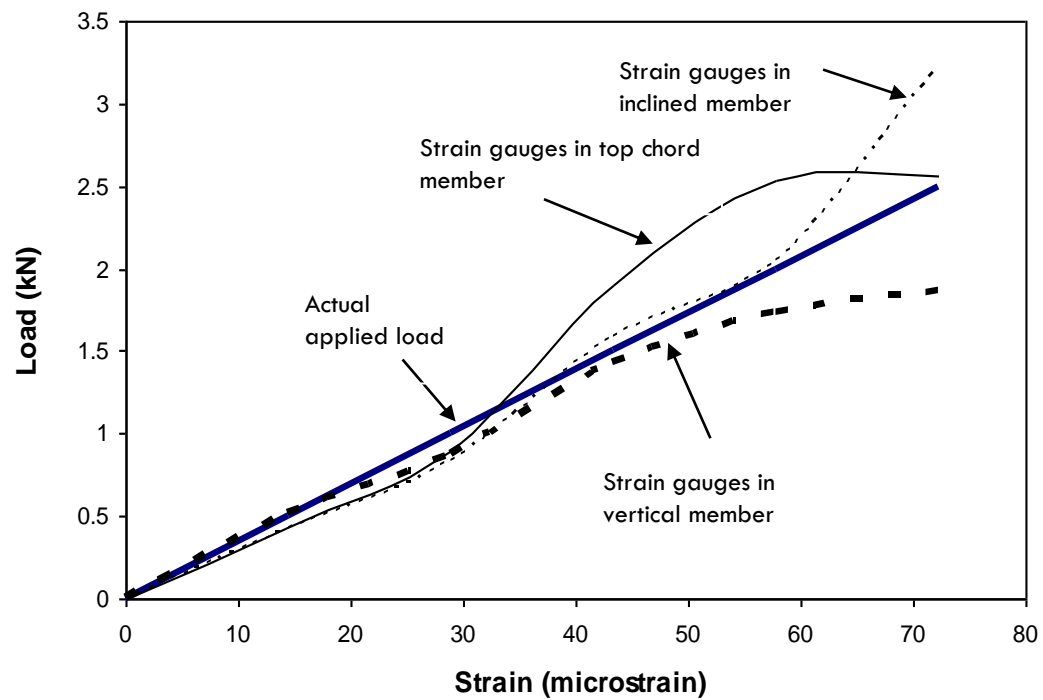
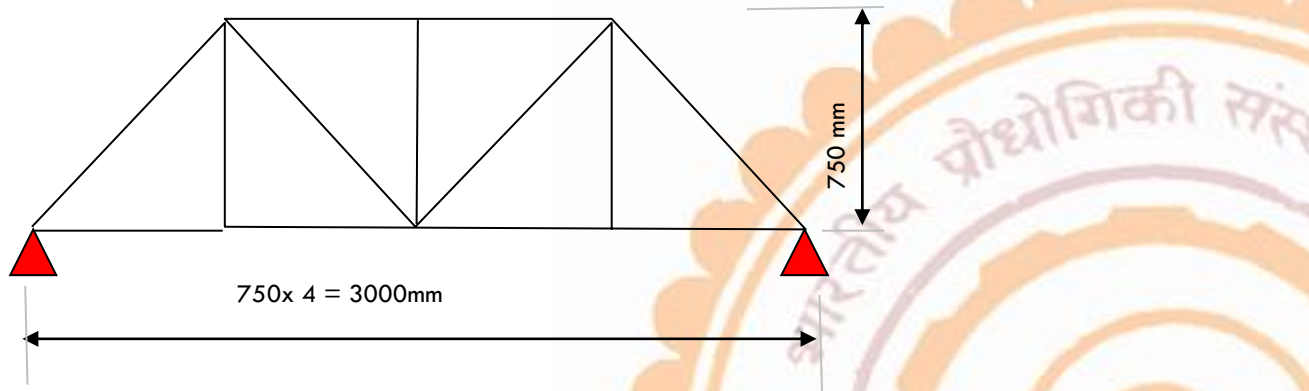
MONITORING OF RC STRUCTURES USING ELECTRICAL STRAIN GAUGES



MONITORING OF TUNNEL LINING



MONITORING OF STEEL TRUSS



ELECTRICAL STRAIN GAUGE (ESG): DRAWBACKS

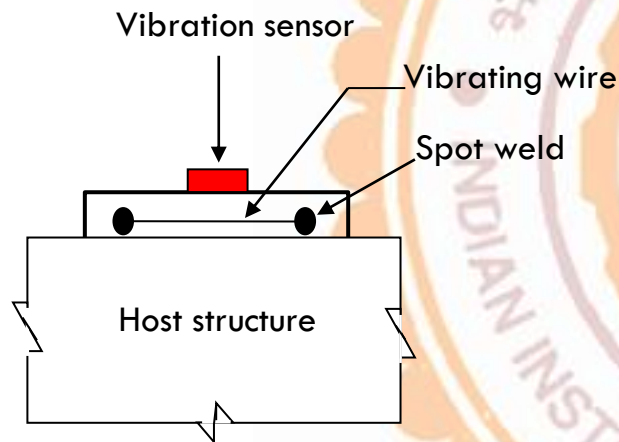
- * Too many wires to handle
- * Prone to electrical noise (electromagnetic interference)
- * Prone to deterioration by water
- * Suffer from decay if loaded for prolonged periods.
- * Best for preliminary short term STATIC monitoring.



VIBRATING WIRE STRAIN GAUGE (VWSG)

A VWSG essentially consists of a pre-tensioned stainless steel wire, with its ends fixed to lugs that are spot-welded to the monitored component.

A sensor coil, positioned over the wire, when energized, plucks the wire and measures the frequency of the resulting vibrations.



$$\Delta \epsilon = \frac{4l^2 \rho}{f} (f_2^2 - f_1^2)$$

$$f = \frac{1}{2l} \sqrt{\frac{T}{m}}$$

$$\epsilon = \left(\frac{4l^2 \rho}{Y} \right) f^2$$

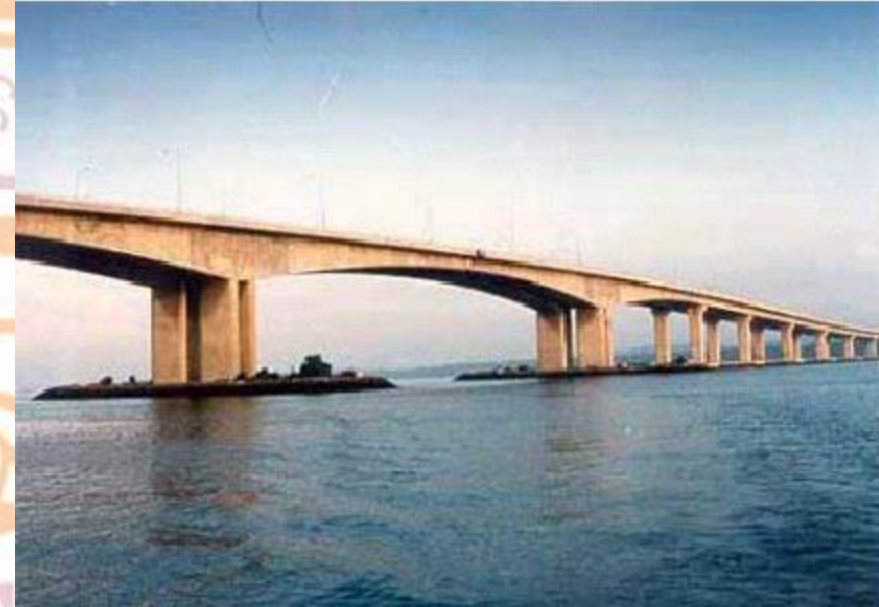
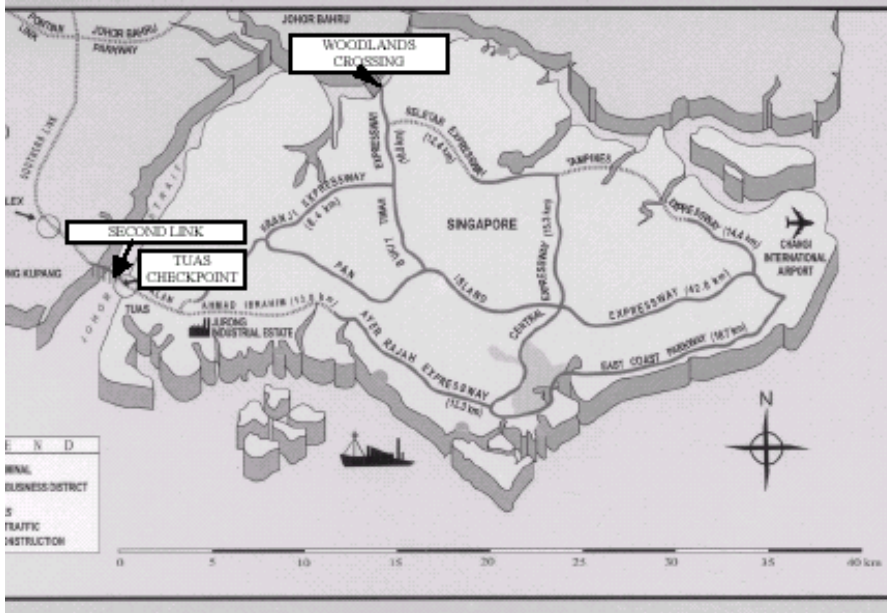
Expand further in terms of strain

T is tension in the wire, l the length and m the mass per unit length

Bakker et al. (2000): Monitoring tunnel linings in Denmark

FOR STUDENTS OF CVL 864 IIT DELHI

INSTRUMENTATION OF SECOND LINK BRIDGE (MOYO, 2002)



1.9 KM LONG COMPRISING 27 SPANS

The bridge was completed in 1997. It was instrumented during construction with vibrating wire strain gauges and continuously monitored.

INSTRUMENTATION OF SECOND LINK BRIDGE (MOYO, 2002)

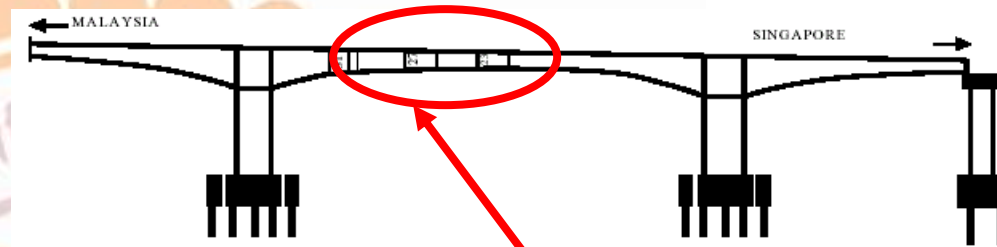
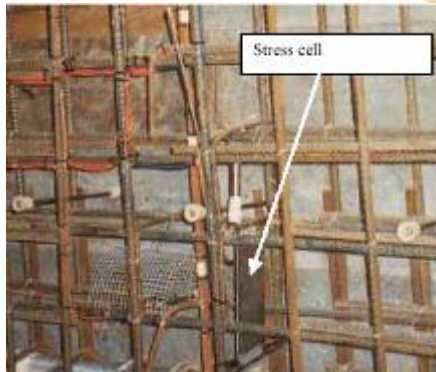
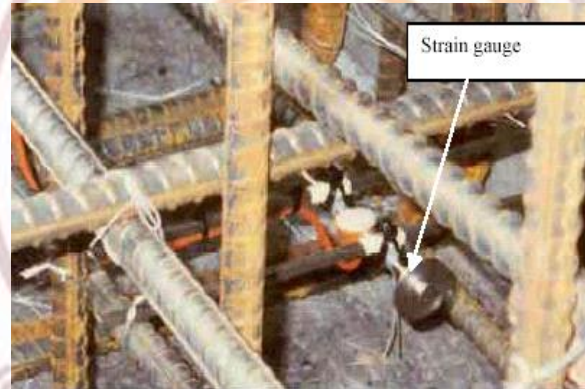


Figure 5.9 : Bridge Layout

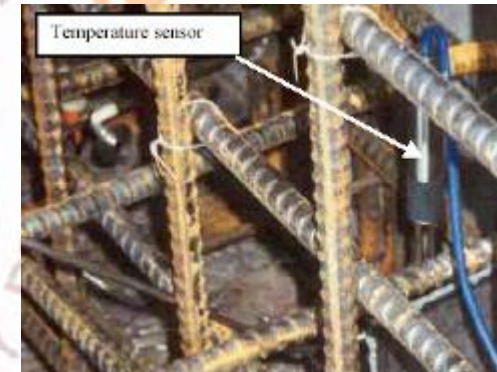
Instrumented segment



12 stress cells



12 vibrating wire strain gauges



40 thermocouples

ALL STATIC DATA WERE RECORDED HOURLY

STRAIN IN SEGMENT 31 DURING CURING

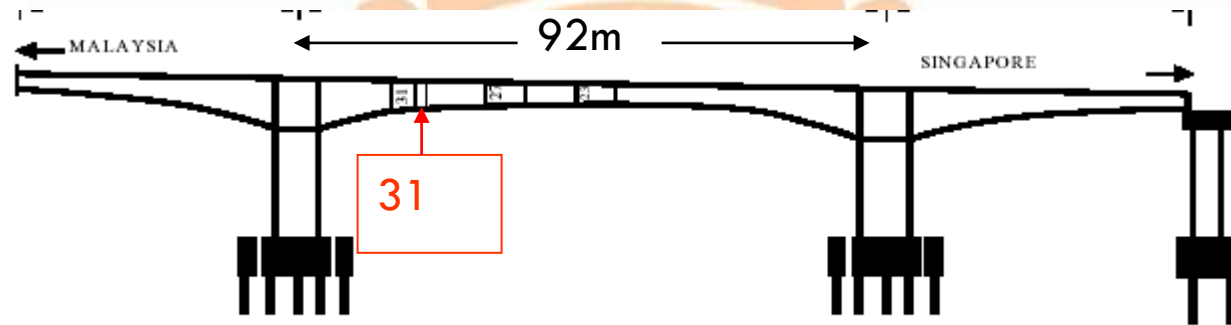
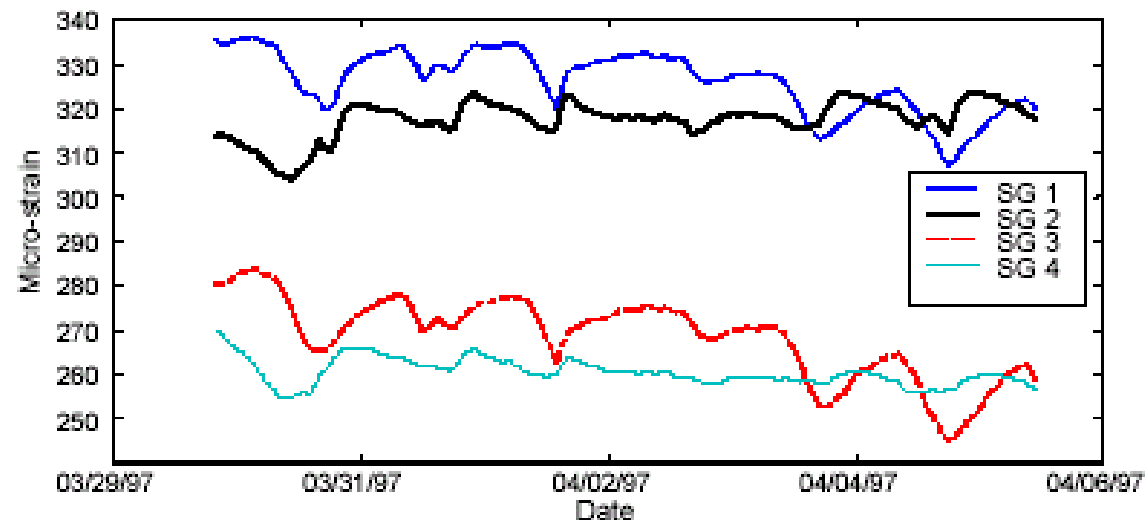


Figure 5.9 : Bridge Layout



Gradually decreasing strain => Shrinkage and hydration
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MONITORING CONSTRUCTION EVENTS FROM STRAIN DATA (SEG 27)

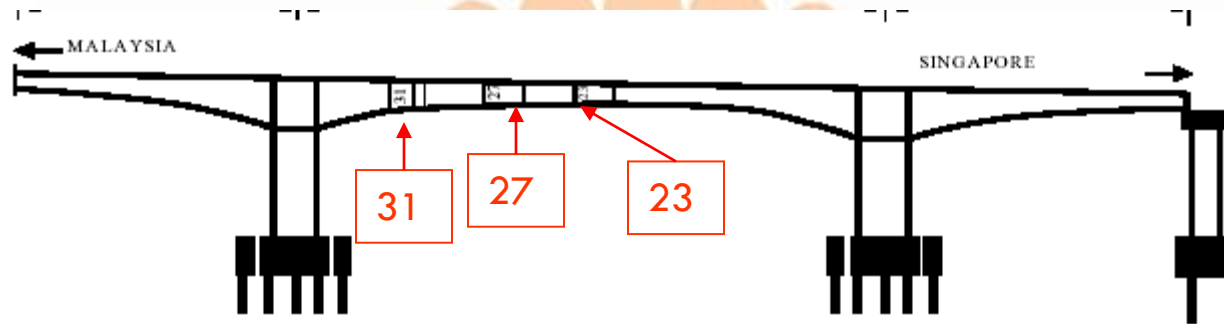
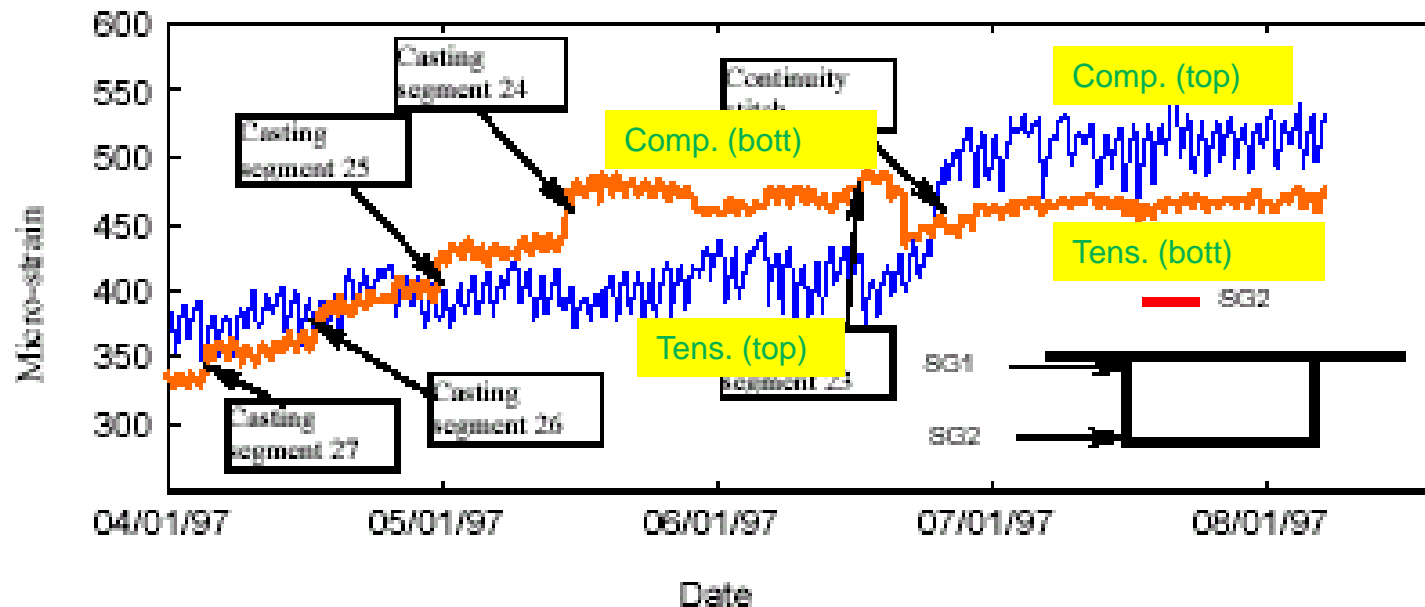
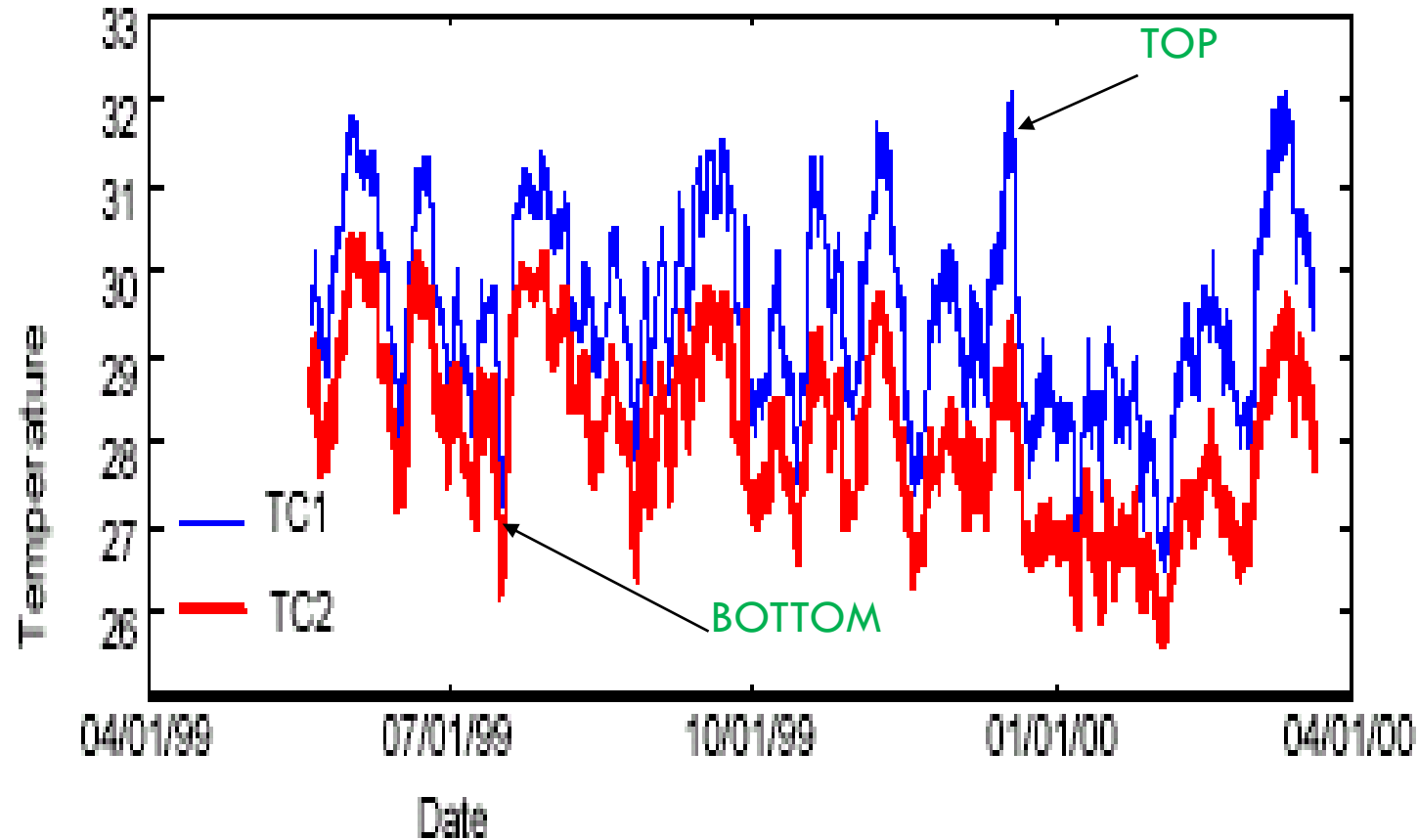


Figure 5.9 : Bridge Layout



All major construction phases can be easily identified
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MONITORING OF TEMPERATURE



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VIBRATING WIRE STRAIN GAUGE: DRAWBACKS

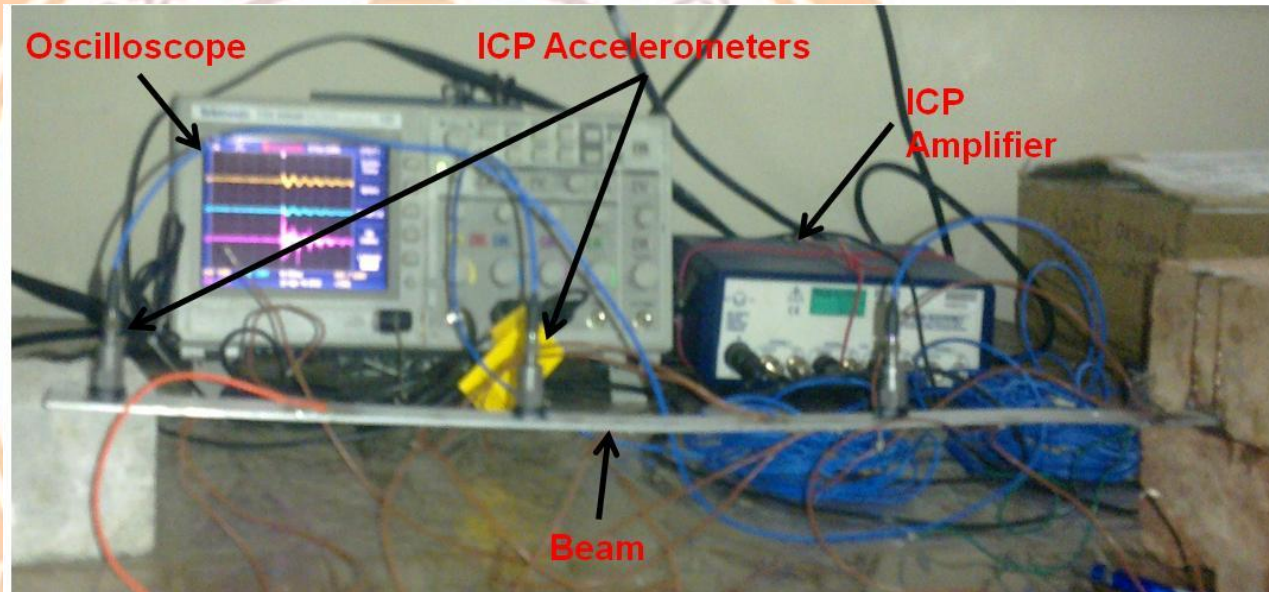
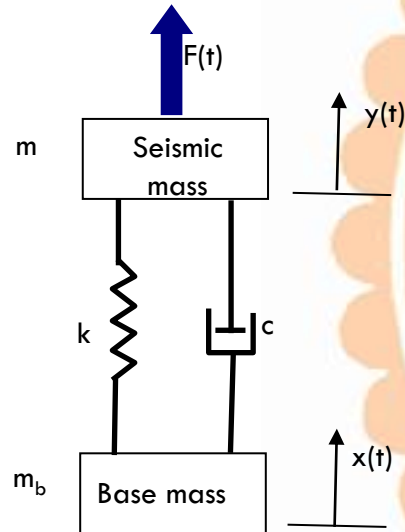
- * Too many wires to handle
- * Suitable for measuring static strains only
- * Prone to noise (ambient vibrations), so not good for dynamic measurements
- * Very expensive (\$ 100 / Rs 7000)



ACCELEROMETER

$$m\ddot{y} + c(\dot{y} - \dot{x}) + k(y - x) = F(t)$$

$$y - x = z$$



For the limiting case of very small frequency ratios

$$\omega \ll \omega_n \quad \ddot{x} \approx -z\omega_n^2$$

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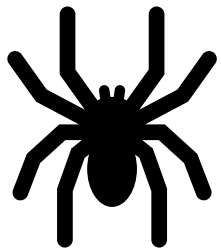
ACCELEROMETER: DRAWBACKS

- * Very expensive (Typically over \$500 or Rs 35, 000)
- * Low bandwidth
- * Very fragile
- * Vandalism is an issue

SMART MATERIALS

SMART MATERIALS possess the ability to change **SPECIFIC** physical **PROPERTY** when subjected to a **SPECIFIC STIMULUS** input

U.S. Army Research Office Workshop on Smart Materials, Structures and Mathematical Issues, September 15-16, 1988, Virginia Polytechnic Institute & State University.



Stimulus



Response

- **Optical Fibres**
- **Shape Memory Alloys**
- **Electro-Rheological Fluids**
- **Piezoelectric Materials**

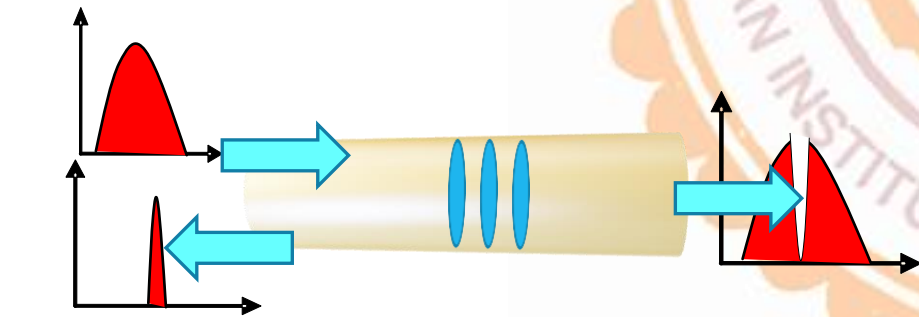
FOR STUDENTS OF CVL 864 IIT DELHI

OPTICAL FIBRES

- Flexible glass (silica) fibres (0.25 to 0.5 mm diameter)
- Used in communication
- Total internal reflection

FIBRE-BRAGG GRATING (FBG) BASED SENSORS

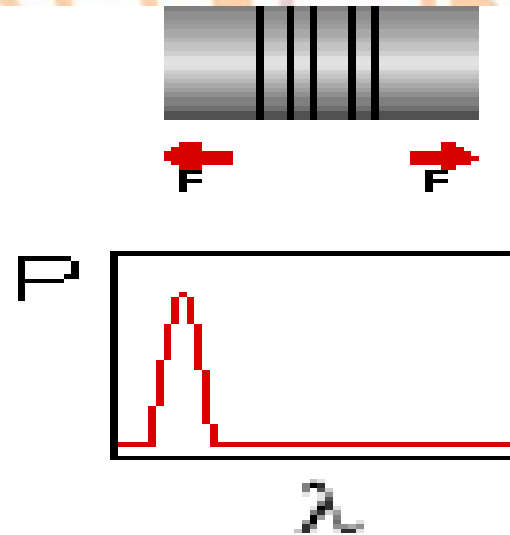
- **FBG:** Set of gratings imprinted in a small segment of optical fibre.
- **Reflects** a particular wavelength of light



Bragg wavelength
(λ_B)



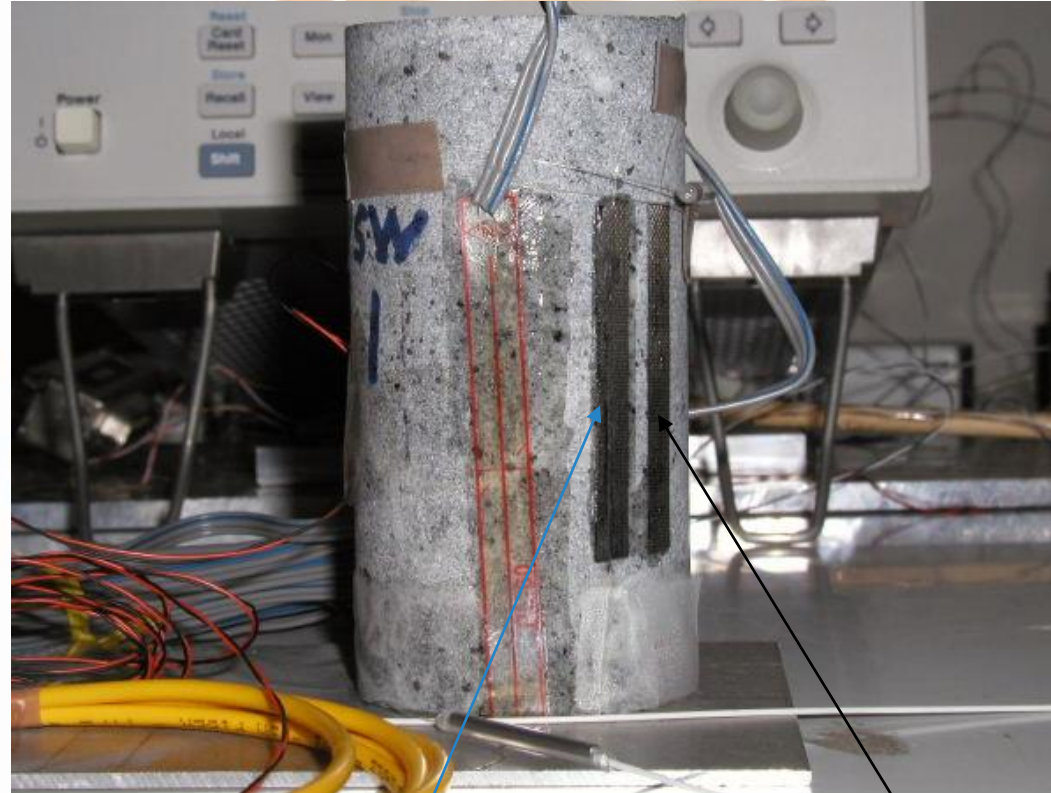
<https://www.elprocus.com/>



- Strain
- Temperature
- Pressure

FOR STUDENTS OF

COMPRESSION TEST ON GRANITE SAMPLES USING FBG SENSORS



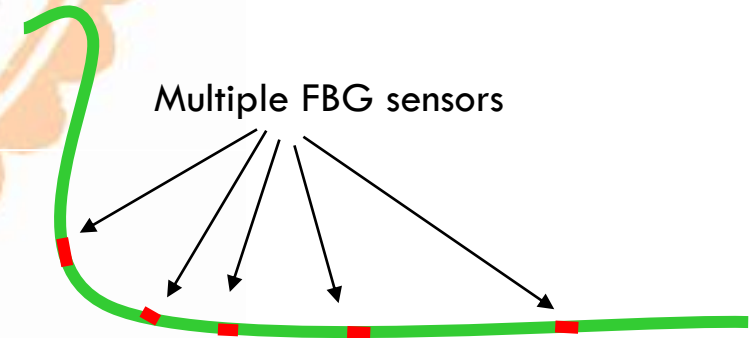
FBG strain sensor

FBG temperature sensor
(strain-free)

ADVANTAGES OF FBG SENSORS FOR STRUCTURAL HEALTH MONITORING

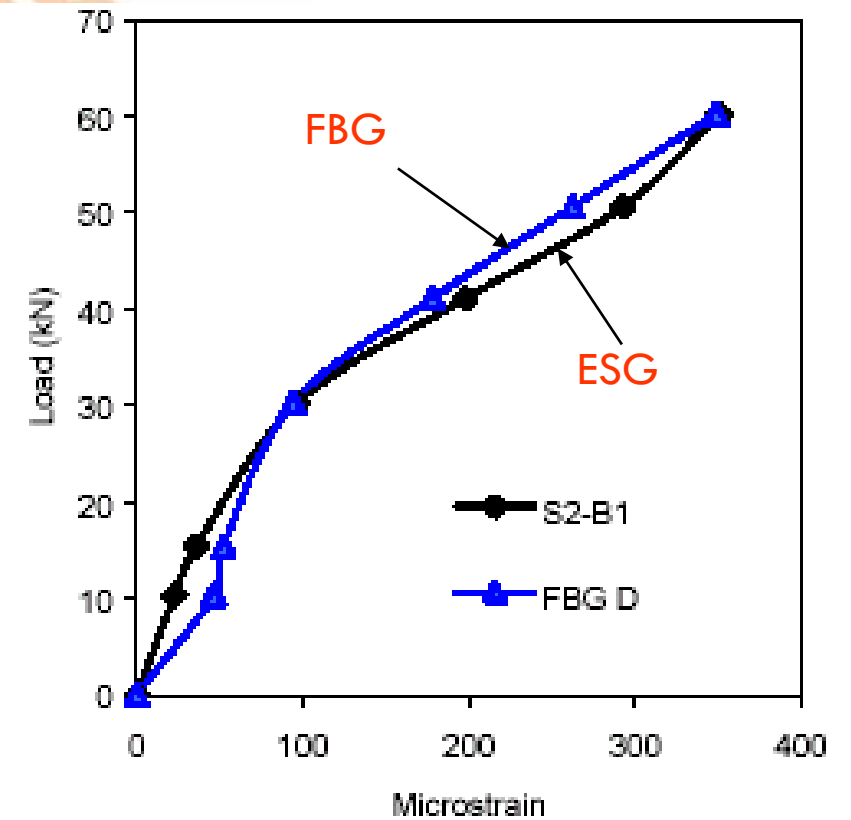
1. Multiplexing potential.
2. A number of FBG sensors on a fiber string can be addressed simultaneously.
3. Small-size ($125\mu\text{m}$), lightweight
4. Immune to EMI, durable under harsh environment and resistant to corrosion.
5. No problem of decay, since based on wavelength and not intensity.

LIMITATIONS?.....Snapping, frequency...



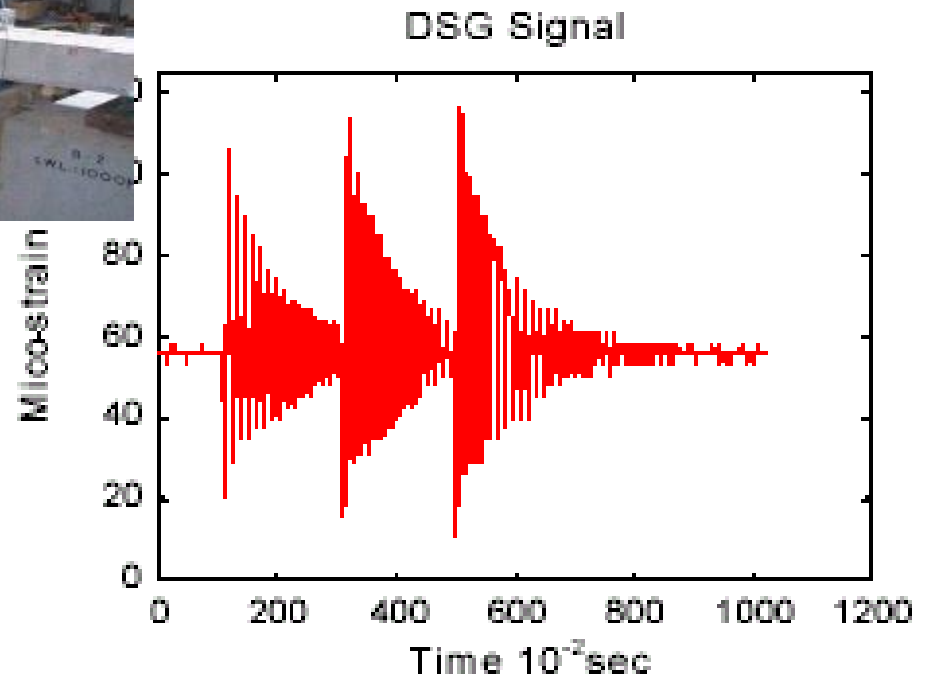
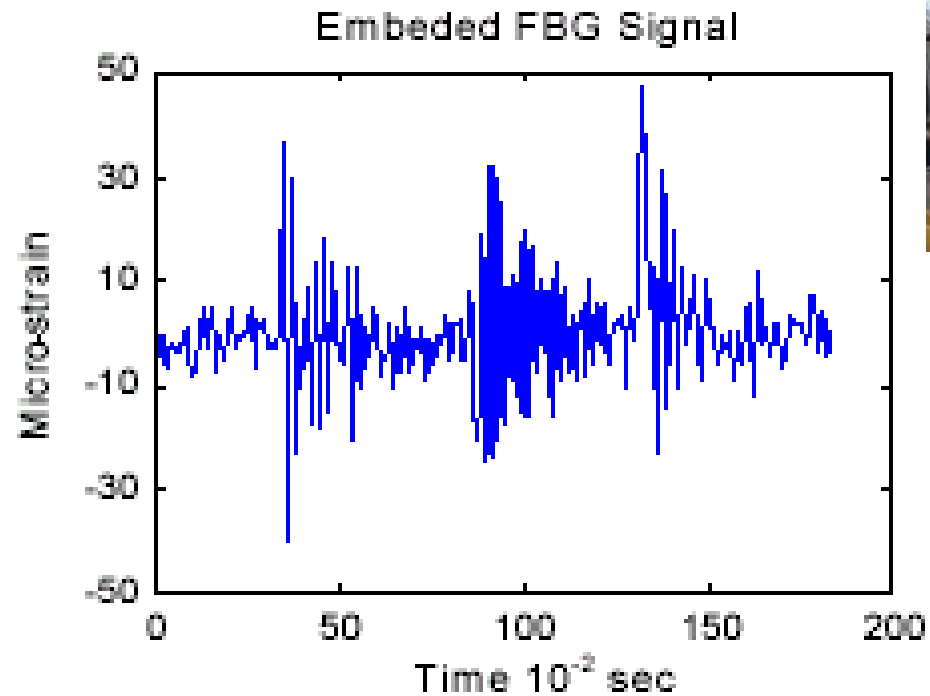
EXPERIMENTAL EVALUATION OF FBG STRAIN SENSORS (MOYO, 2002)

STATIC TEST



EXPERIMENTAL EVALUATION OF FBG STRAIN SENSORS (MOYO, 2002)

DYNAMIC TEST



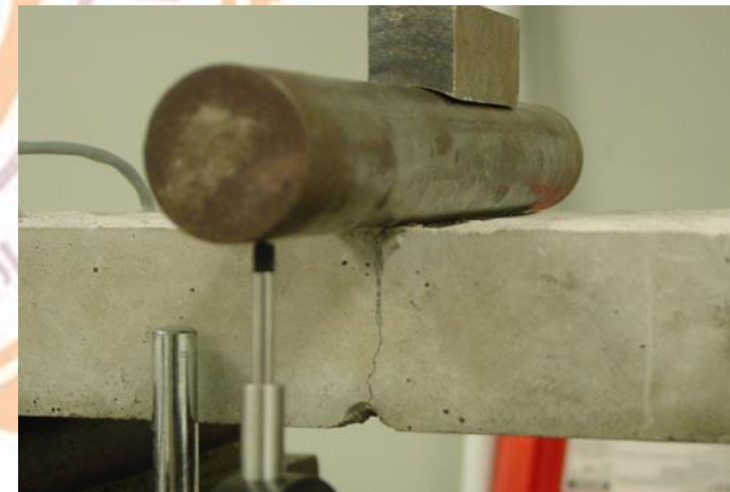
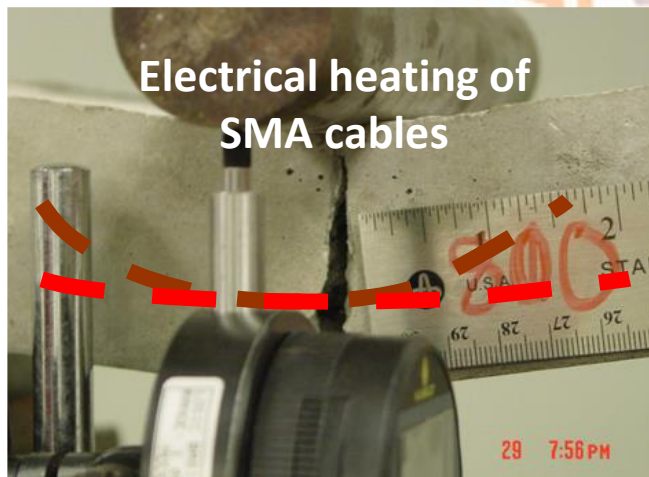
SHAPE MEMORY ALLOYS (SMA)

Possess capability to return “memorized” shape when heated

- **Bio-medical application:** stent insertion to unblock arteries
- **Futuristic application:** damage healing
- **Futuristic applications:** structural control, aircraft wings



<http://www.vhlab.umn.edu/>



Song et al. (2006)

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ELECTRO-RHEOLOGICAL (ER) FLUIDS

ER fluids undergo change in **viscosity** under an electric field

Applications:

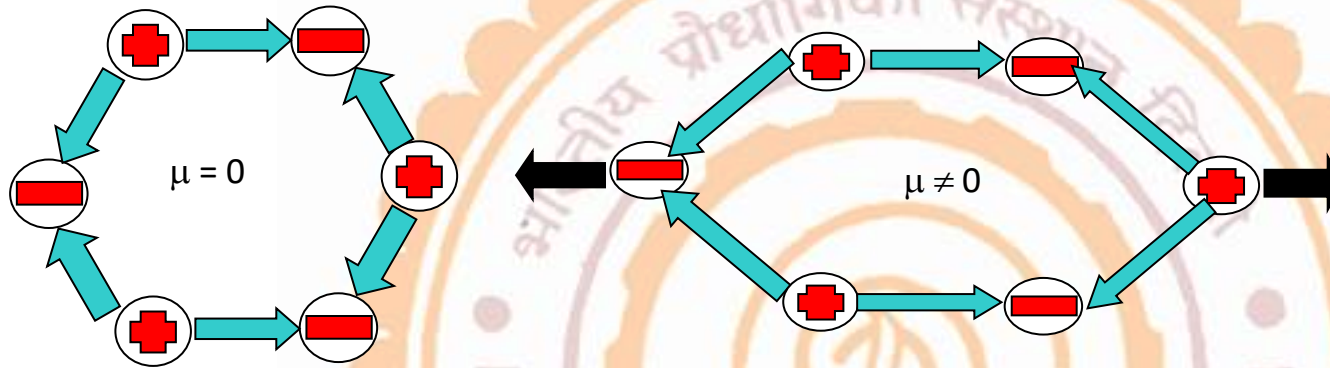
- Shock/ vibration absorption in vehicle suspension
- Hydraulic valves
- Futuristic: Earthquake response control of structures



<https://www.123rf.com/>

PIEZOELECTRIC MATERIALS

The phenomenon of piezoelectricity was discovered by Curie brothers in 1880



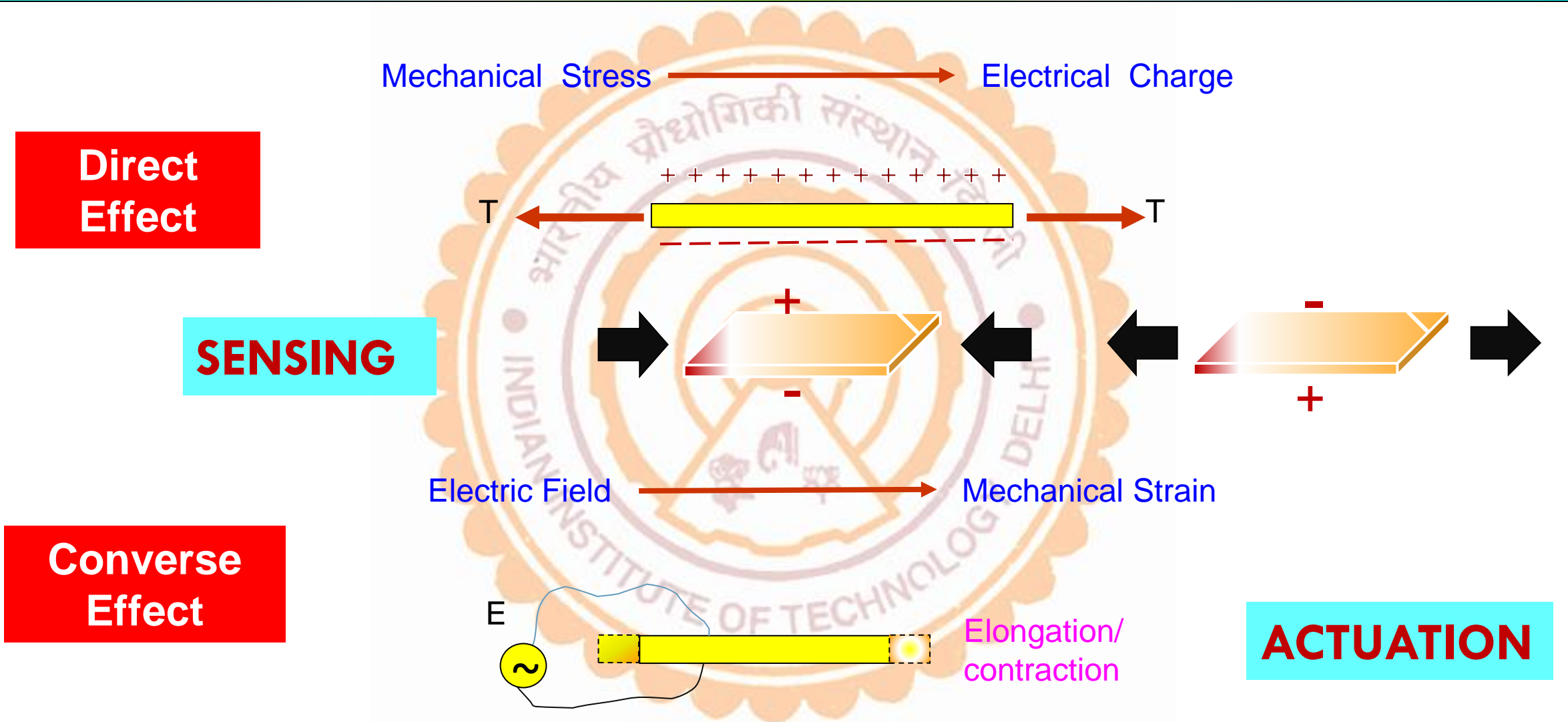
Noncentro-symmetric crystals: the act of stretching causes dipole moment in the crystal (μ = Dipole moment).

It occurs in non-centro symmetric crystals, such as:

- Quartz (SiO_2)
- Lithium Niobate (LiNbO_3)
- Lead Zirconate Titanate PZT [$\text{Pb}(\text{Zr}_{1-x}\text{Ti}_x)\text{O}_3$]
- Lead-Lanthanum-Zirconate-Titanate PLZT [$(\text{Pb}_{1-x}\text{La}_x)(\text{Zr}_{1-y}\text{Ti}_y)\text{O}_3$]

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PIEZOELCTRIC MATERIALS



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APPLICATIONS

DIRECT EFFECT

Igniters/ detonators, accelerometers, tactile sensors, pressure transducers, dynamic strain sensors, mobile phones (mic), structural health monitoring, energy harvesting



Sound to electrical pulses

CONVERSE EFFECT

Mobile phones (speaker), fuel injectors, musical cards, inkjet printers, vibration control, turbo-machinery, actuators, precision positioning



electrical pulses to sound

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PIEZOELECTRIC MATERIALS

There are over 200 types of piezoelectric materials available commercially: **ceramics and polymers**

Lead Zirconate Titanate (PZT) is the most widely used ceramic type piezoelectric material. It has **high stiffness** but is at the same time **brittle**.

Polyvinylidene Fluoride (PVDF) is popular polymer. It is **ductile** but has **less stiffness**.

COMMERCIAL FORMS

CERAMICS

LEAD ZIRCONATE
TITANATE (PZT)



Higher strength, stiffness, but brittle

Suitable as sensor and actuator

POLYMERS

POLYVINYLIDENE
FLUORIDE (PVDF)



Lesser strength, stiffness, but ductile, shape conformability

Suitable as sensor

OTHER SPECIAL TYPES

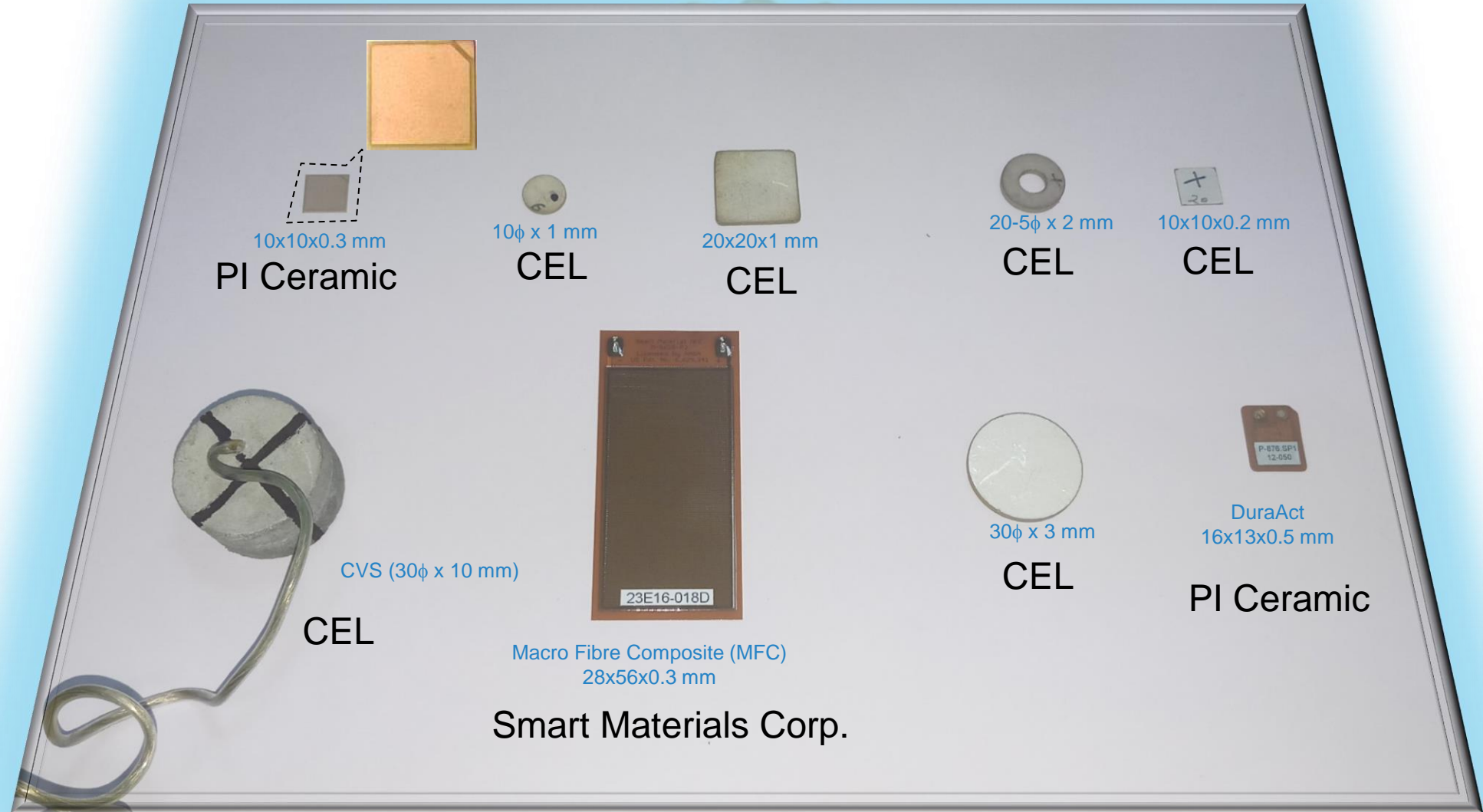


DuraAct

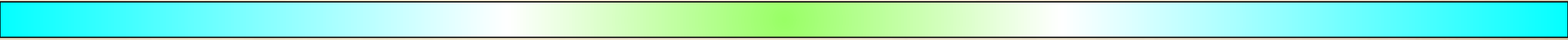
Macro Fibre Composite (MFC)



COMMERCIAL FORMS OF PZT



SPECIAL FLEXIBLE FORM



**Macro Fibre
Composite (MFC)**

Smart Materials Corp.

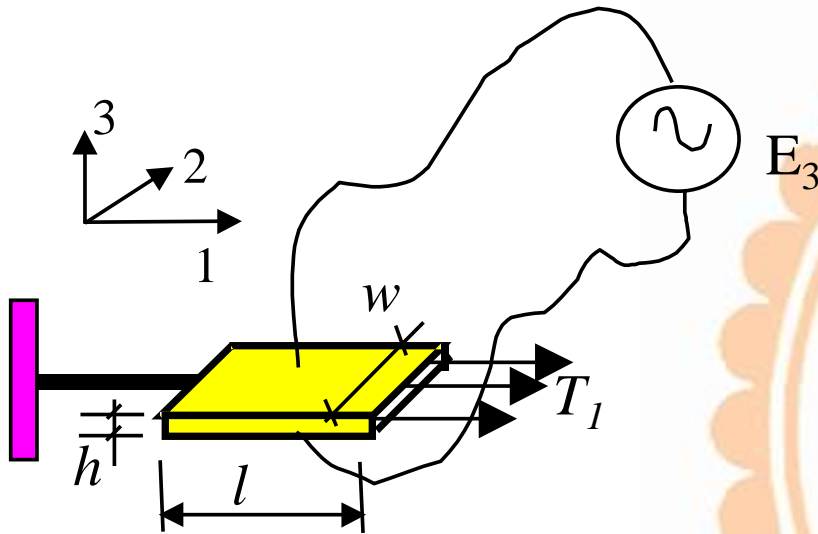
COMPOSITE CONFIGURATION



Ready to use PZT-cement composite sensor, developed by SSD Lab, for concrete structures

Concrete Vibration
Sensor (CVS)

CONSTITUTIVE RELATIONS



$\overline{Y^E}$ Young's modulus under constant (zero) electric field

$\overline{\epsilon_{33}^T}$ Electric permittivity under constant (zero) stress

Converse Effect

Strain Stress Electric field

$$S_1 = \frac{T_1}{Y^E} + d_{31} E_3$$

Linearly elastic material

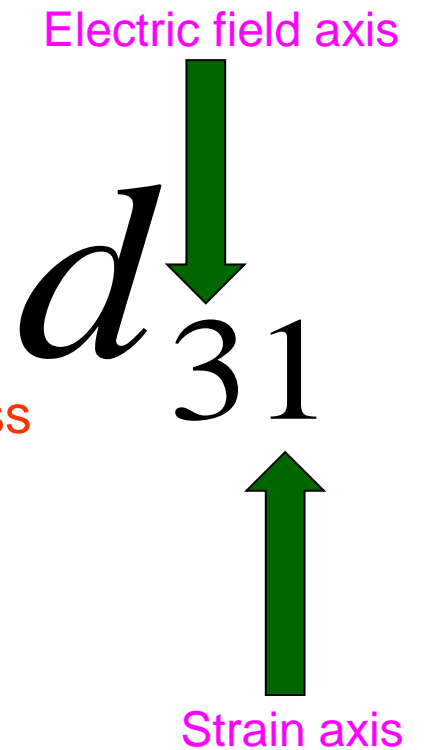
Piezoelectric strain coefficient

Direct Effect

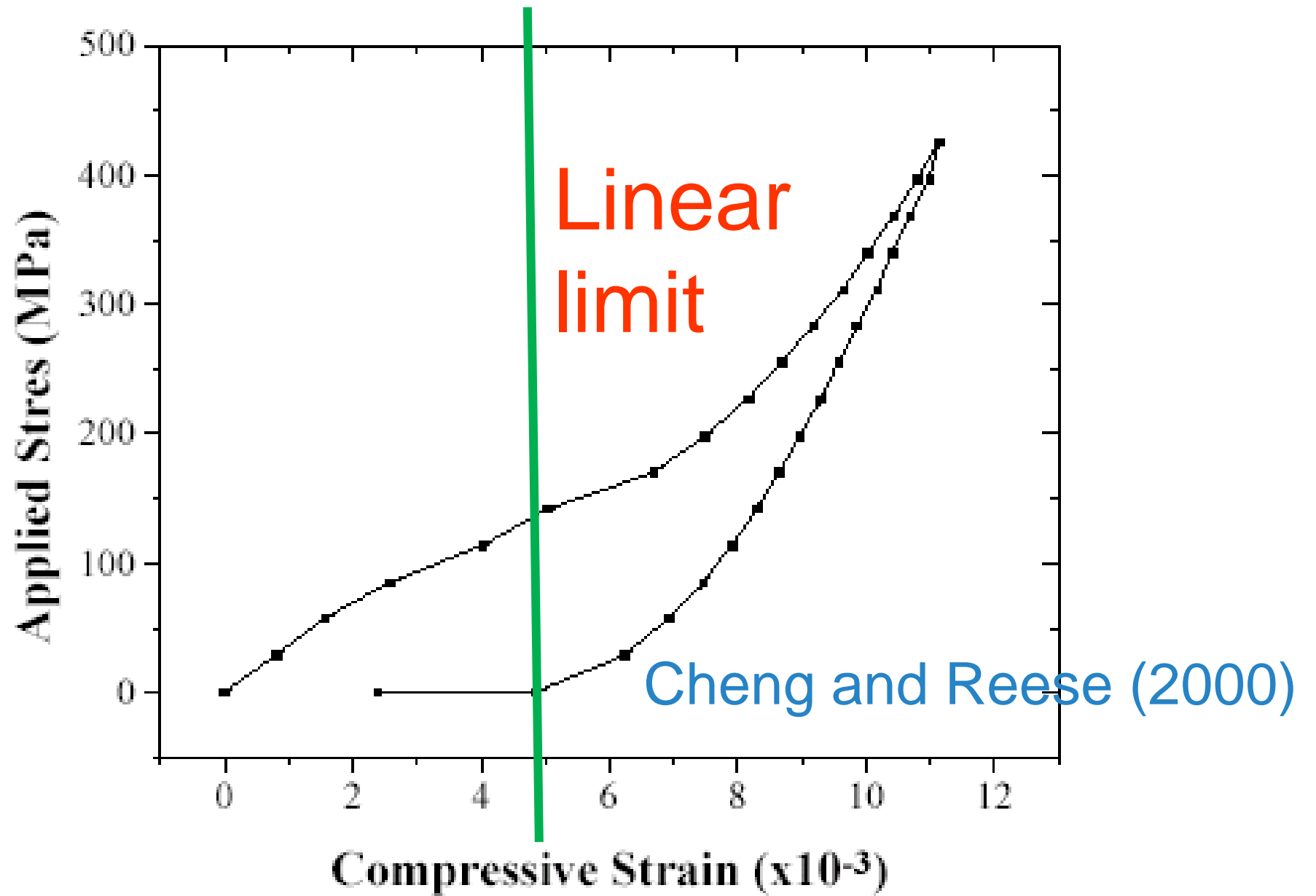
Charge density Electric field Stress

$$D_3 = \overline{\epsilon_{33}^T} E_3 + d_{31} T_1$$

Dielectric material



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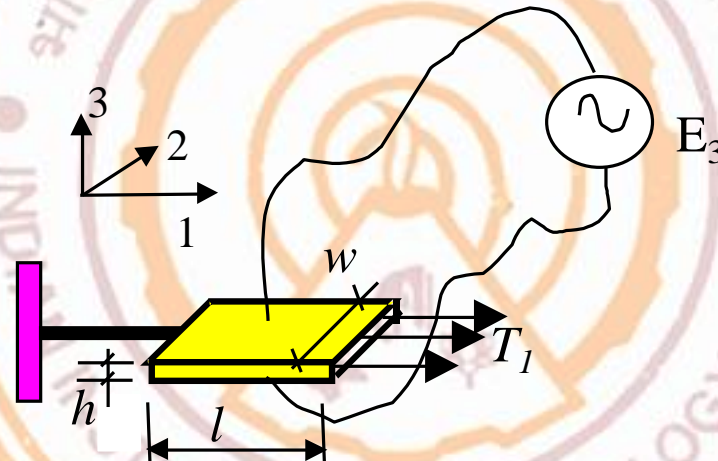
PIEZOELCTRIC STRAIN COEFFICIENT

d_{31}

d_{31}

= Strain per unit electric field under zero (constant) stress conditions (unit m/V)

$$S_1 = \frac{T_1}{Y_{11}^E} + d_{31}E_3$$



d_{31}

= Charge density induced by unit stress under zero (constant) external electric field (unit C/N)

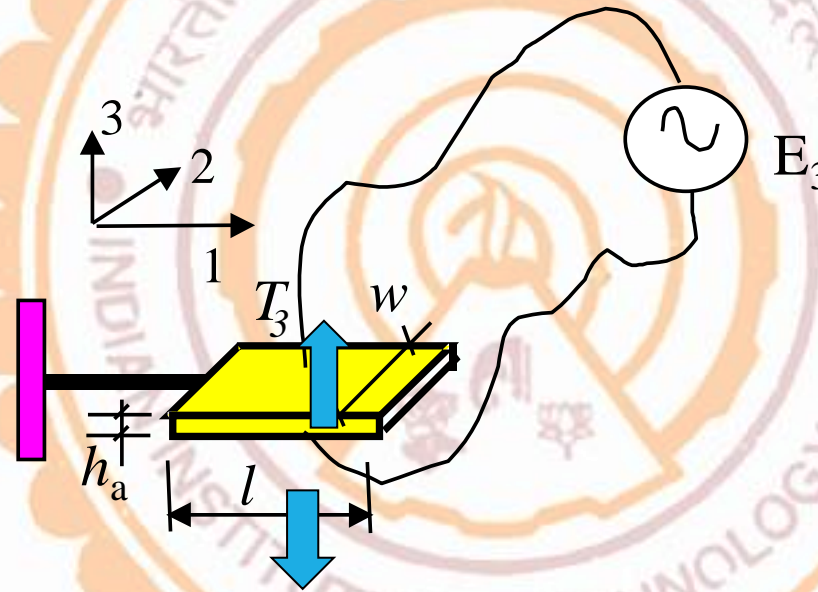
$$D_3 = \overline{\epsilon}_{33}^T E_3 + d_{31}T_1$$

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PIEZOELCTRIC STRAIN COEFFICIENT d_{33}

This comes into picture when both electric field and stress are along axis "3"

$$S_3 = \frac{T_3}{Y_{33}^E} + d_{33}E_3$$



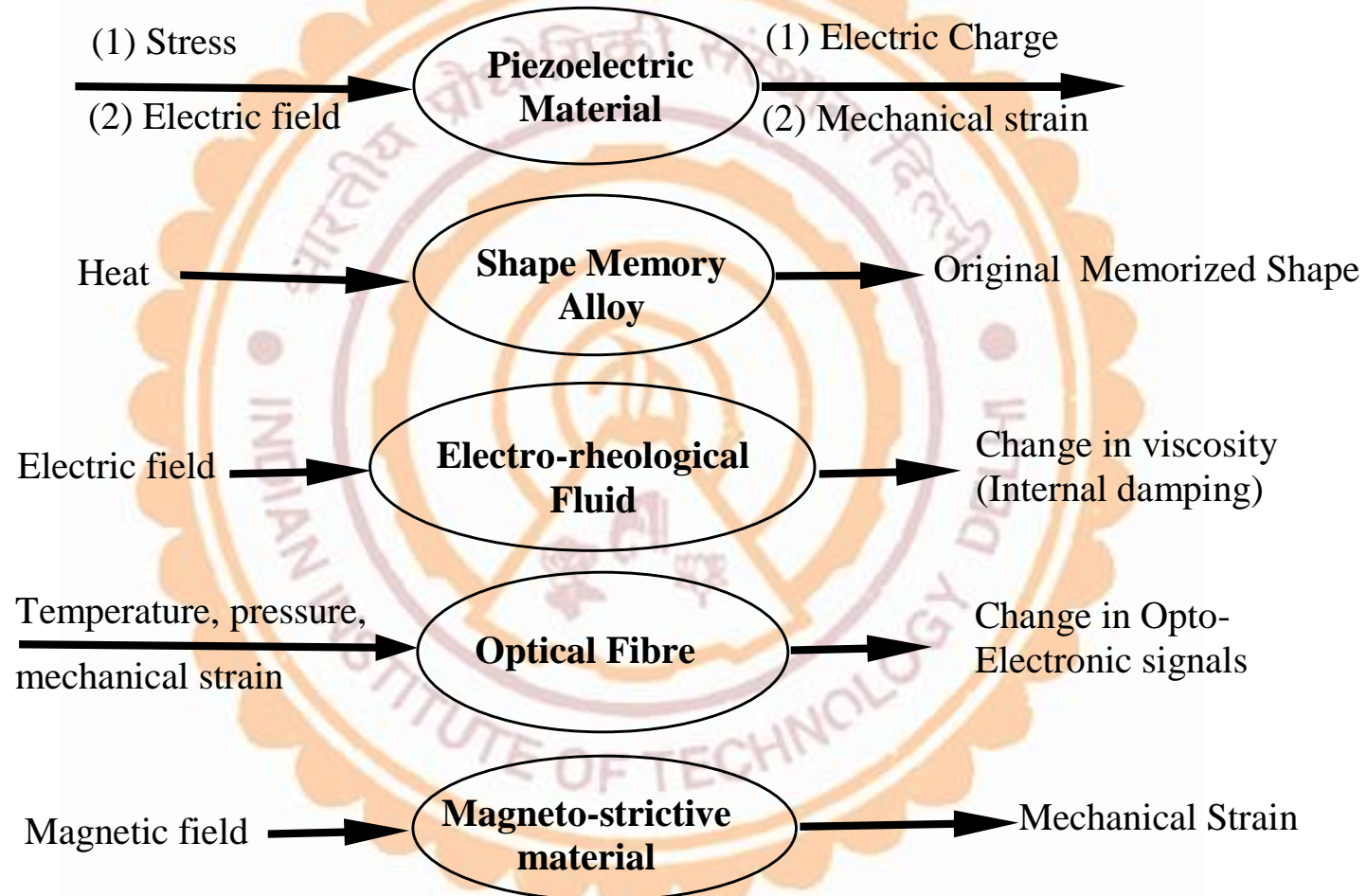
$$D_3 = \overline{\epsilon}_{33}^T E_3 + d_{33}T_3$$

In general for PZT material, d_{31} is negative, which means an electric field in positive "3" direction induces compressive strain along axis "1"

In contrast, d_{33} is positive

FOR STUDENTS OF CVL 864 IIT DELHI

SUMMARY: SMART MATERIALS



DYNAMIC STRAIN SENSOR

Direct Effect

$$D_3 = \overline{\epsilon_{33}^T} E_3 + d_{31} T_1$$

Charge density Electric field Stress

zero

Potential difference across terminals

Thickness of PZT patch

$$V = \left(\frac{d_{31} h Y^E}{\overline{\epsilon_{33}^T}} \right) S_1 = k S_1$$

$$Q = CV$$

Voltage Charge Capacitance

Voltage \propto Strain

Sensitivity = 200mV/($\mu\text{m}/\text{m}$)

FOR STUDENTS OF CVL 864 IIT DELHI

DYNAMIC STRAIN SENSOR

PZT PATCHES ARE SUITABLE FOR DYNAMIC STRAINS AND NOT STATIC STRAINS.....

- The piezoelectric effect is dynamic, i.e.,
- Charge is generated only when the forces are changing
 - The initial charge will decay in circuit if the force remains constant.....

EXERCISE

			Soft PZT materials			
		Unit	PIC151	PIC255/ PIC252 ¹⁾	PIC155	PIC153
Physical and dielectric properties						
Density	ρ	g/cm ³	7.80	7.80	7.80	7.60
Curie temperature	T_c	°C	250	350	345	185
Relative permittivity	in the polarization direction	$\epsilon_{33}^T/\epsilon_0$	2400	1750	1450	4200
	⊥ to polarity	$\epsilon_{11}^T/\epsilon_0$	1980	1650	1400	
Dielectric loss factor	$\tan \delta$	10 ⁻³	20	20	20	30
Electromechanical properties						
Coupling factor	k_p		0.62	0.62	0.62	0.62
	k_t		0.53	0.47	0.48	
	k_{31}		0.38	0.35	0.35	
	k_{32}		0.69	0.69	0.69	
	k_{15}			0.66		
Piezoelectric charge coefficient	d_{31}		-210	-180	-165	
	d_{32}	10 ⁻¹² C/N	500	400	360	600
	d_{15}			550		
Elastic compliance coefficient	S_{11}^E		15.0	16.1	15.6	
	S_{33}^E	10 ⁻¹² m ² /N	19.0	20.7	19.7	

$$V = \left(\frac{d_{31} h \overline{Y^E}}{\epsilon_{33}^T} \right) S_1 = k S_1$$

Determine : K

ORIGIN OF TERM

$$D_3 = \overline{\varepsilon}_{33}^T E_3 + d_{31} T_1$$

$$Q = CV$$

$$D_3 A = \left[\begin{array}{c} \overline{\varepsilon}_{33}^T A \\ h \end{array} \right] V$$

$$D_3 = \overline{\varepsilon}_{33}^T E_3$$

A bar above a parameter implies it is measured under dynamic conditions

COMPARATIVE STUDY

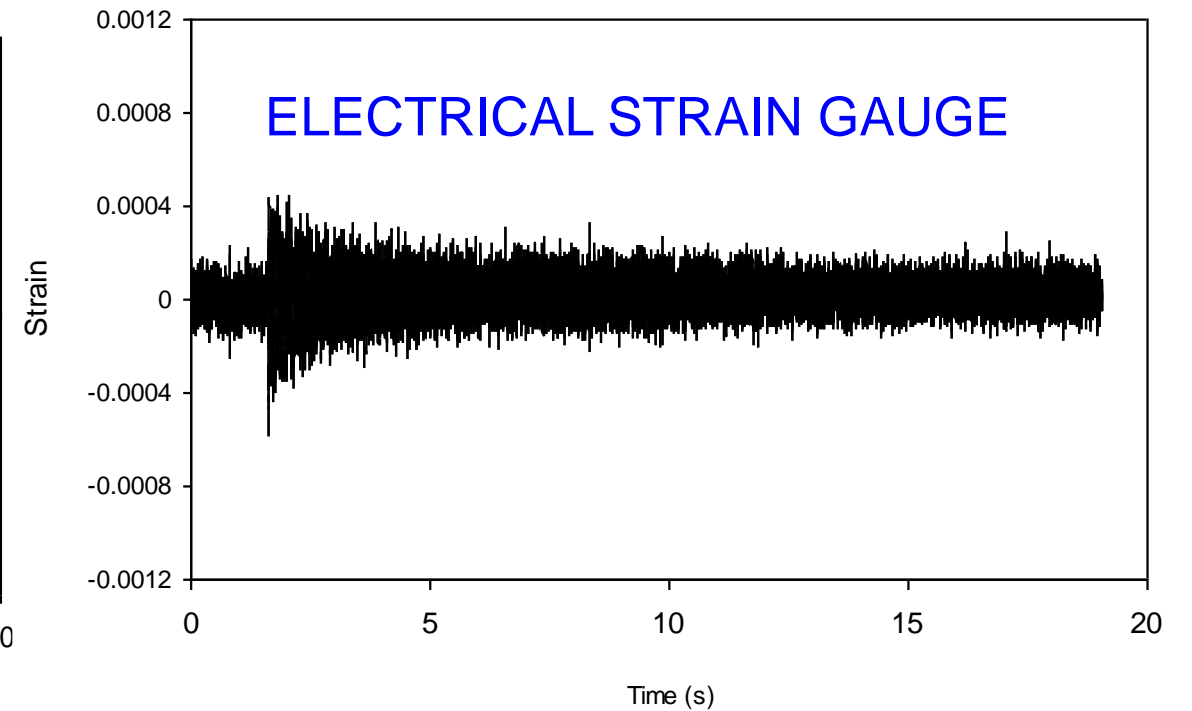
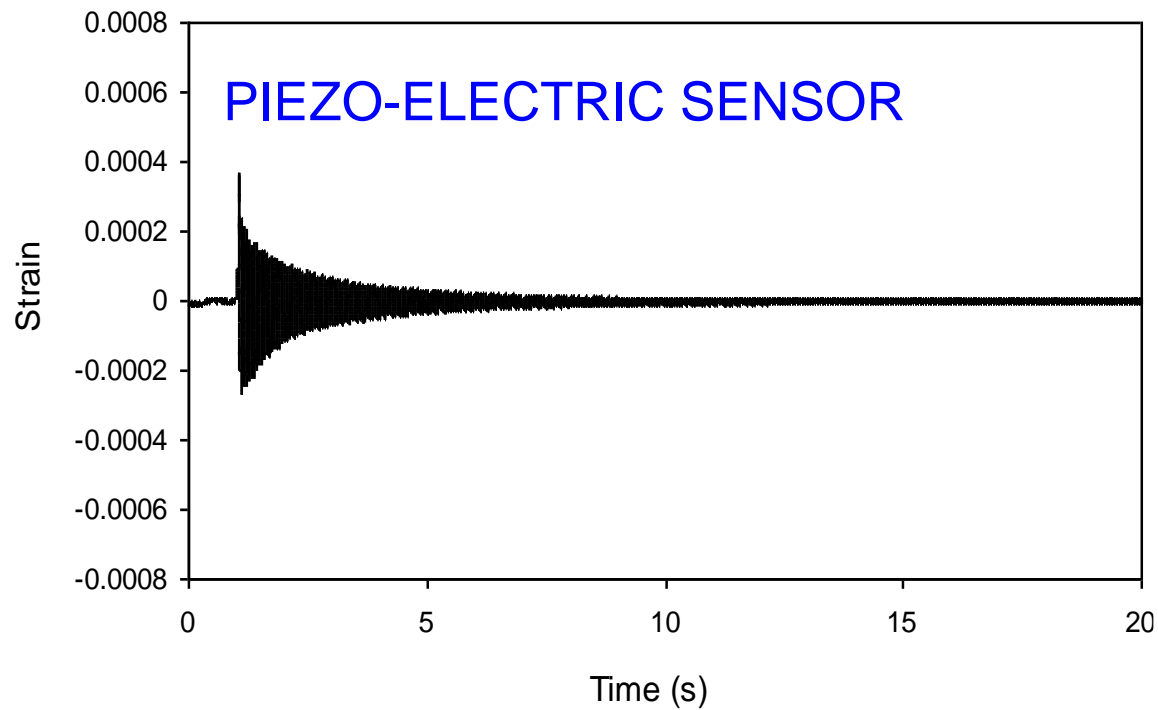
FOLLOWING SENSORS EVALUATED FOR DYNAMIC RESPONSE

Electrical strain gauges (ESG)

Piezoelectric ceramic (PZT) sensor

Accelerometers

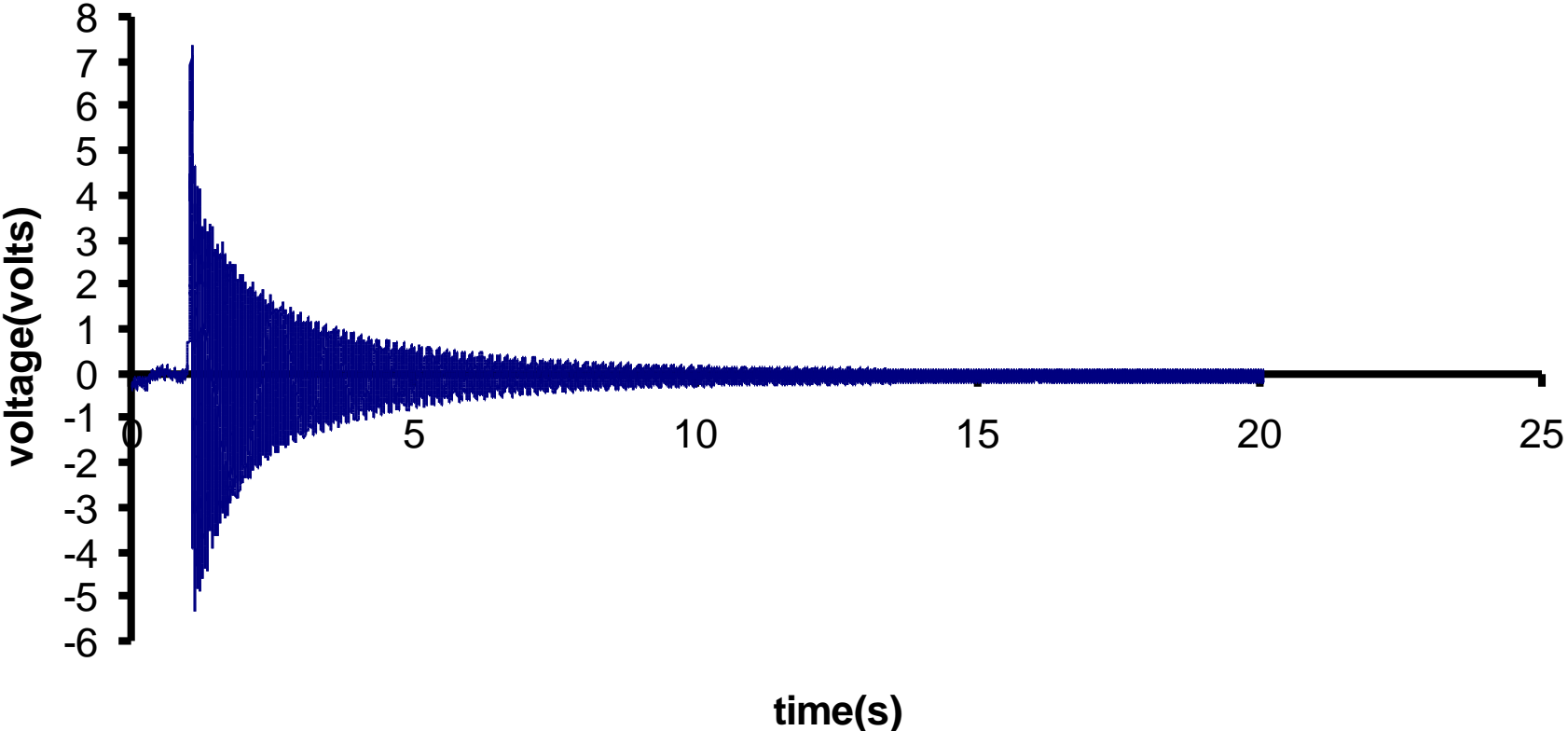
FOR STUDENTS OF CVL 864 IIT DELHI



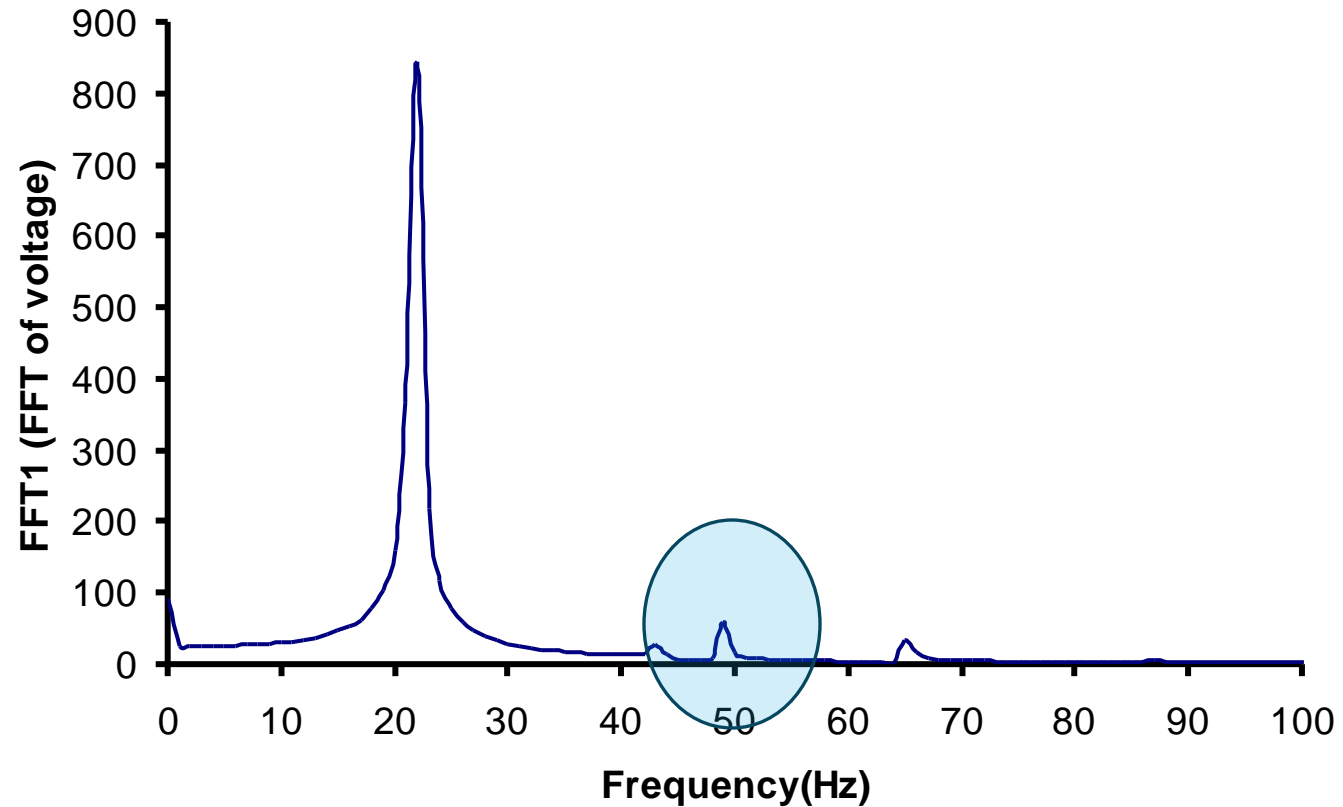
What are observations related to signal to noise ratio (SNR) ??

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RESPONSE USING PZT PATCH (TIME DOMAIN)



RESPONSE USING PZT PATCH (FREQUENCY DOMAIN)



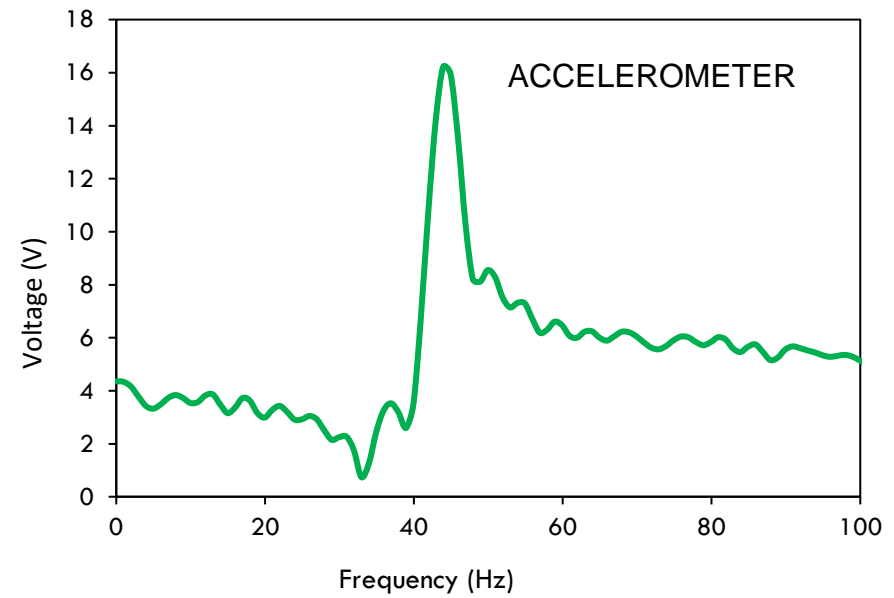
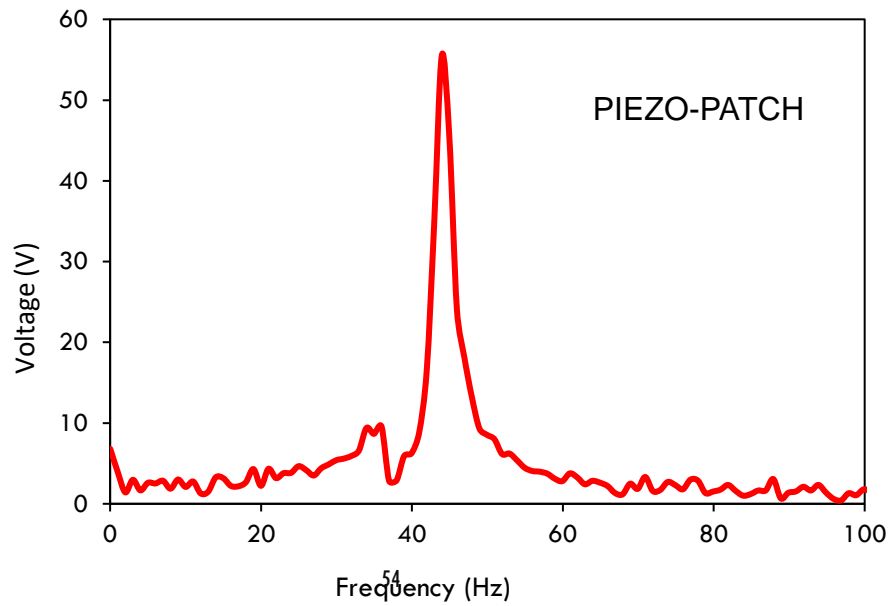
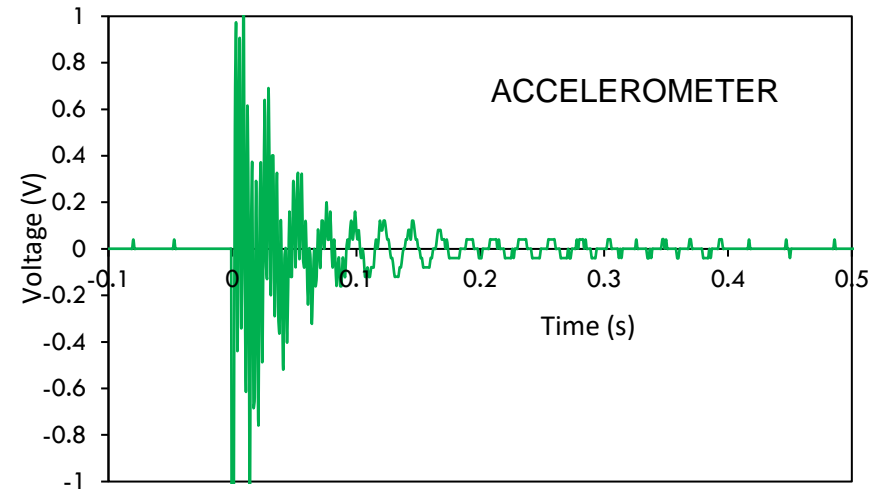
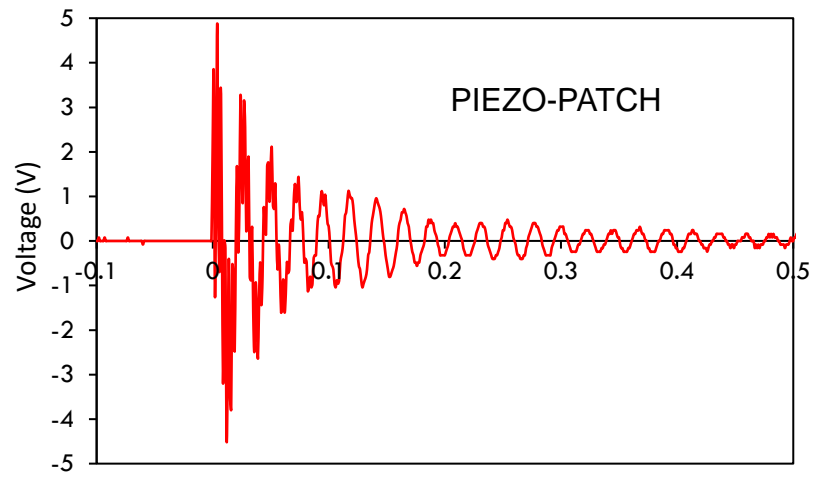
Digital multimeter
(Agilent 34411A)

Personal computer

Hammer

Sensors

Test specimen



IMPORTANT OBSERVATIONS

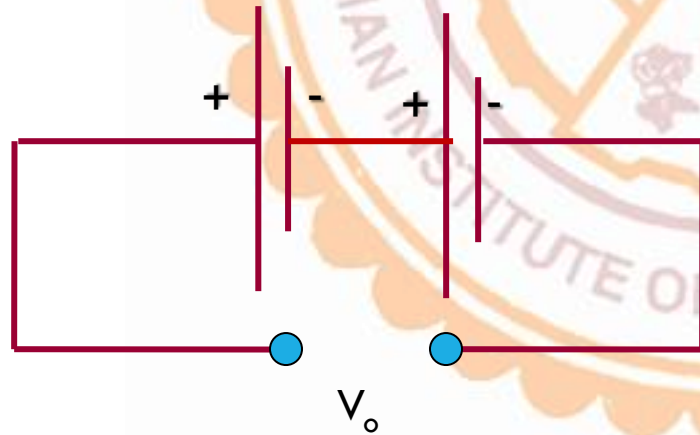
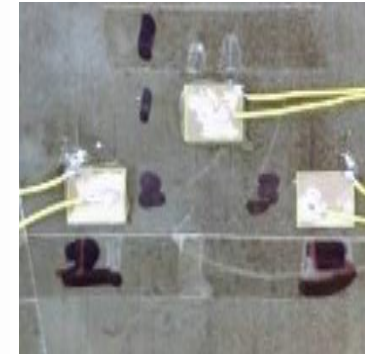
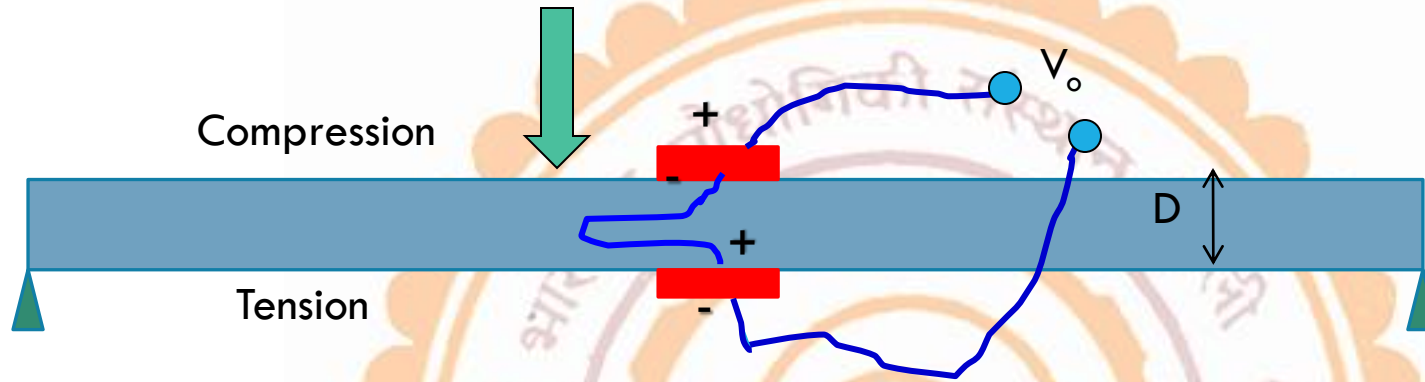
- **WORST RESPONSE IN CASE OF ESG**
TYPICAL COST: \$1.5 (Rs 100)
- **BEST RESPONSE IN CASE OF ACCELEROMETER**
TYPICAL COST: \$500 (Rs 35, 000 and above)
(Also bulky, bandwidth limitation)
- **PZT PATCH: RESPONSE QUALITY ALMOST COMPARABLE TO ACCELEROMETER**
TYPICAL COST: \$1-10 (Rs 70-700)

SHM BY PZT PATCHES

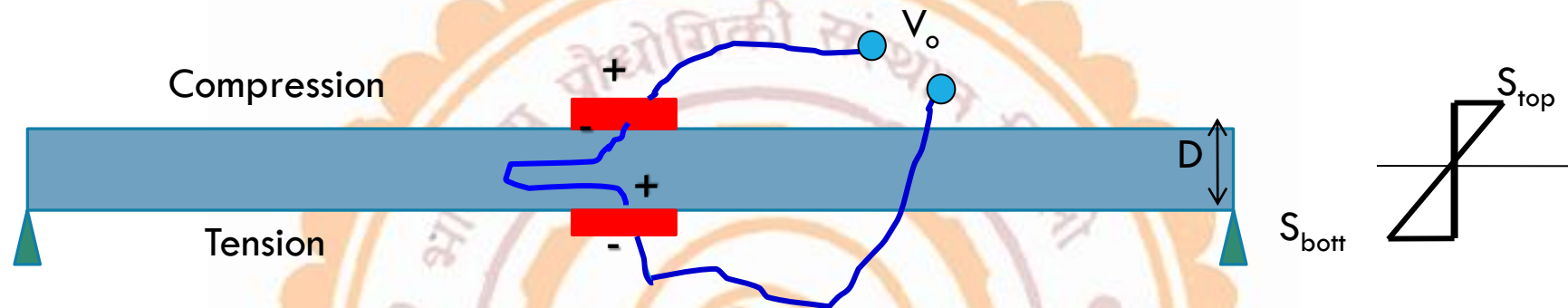
Two modes

- (a) Dynamic strain sensor**
Direct effect, low-frequency
- (b) Electro-mechanical impedance (EMI) sensor**
Direct+ converse effect, high-frequency

SENSING OF FLEXURE



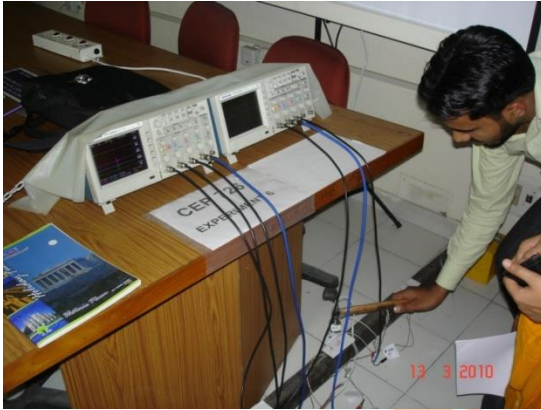
SENSING OF FLEXURE



$$V_o = k(S_{top} + S_{bott}) \quad \phi = \frac{S_{top} + S_{bott}}{D}$$

Curvature

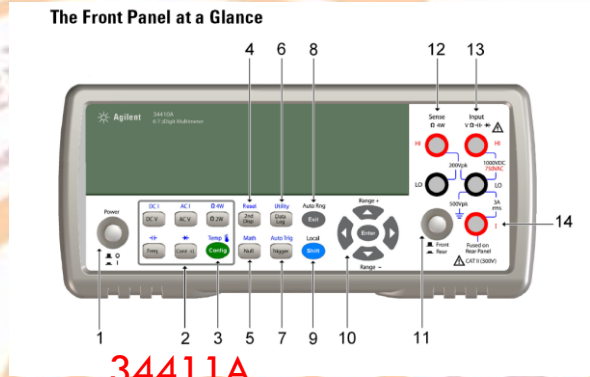
$$\phi = \frac{S_{top} + S_{bott}}{D} = \frac{V_o}{kD} \text{ Voltage } \propto \text{Curvature}$$



TDS 2004B

Tecktronix oscilloscope

Four channel, real-time, low on resolution IMPORTED



34411A

Agilent digital multimeter

Single channel, near real-time, high on resolution IMPORTED



QDA 1000

Quazar Technologies

<http://www.quazartech.com>

Eight channel, real-time, high on resolution, INDIGENOUS



U2331

USB Modular Multifunction Data Acquisition

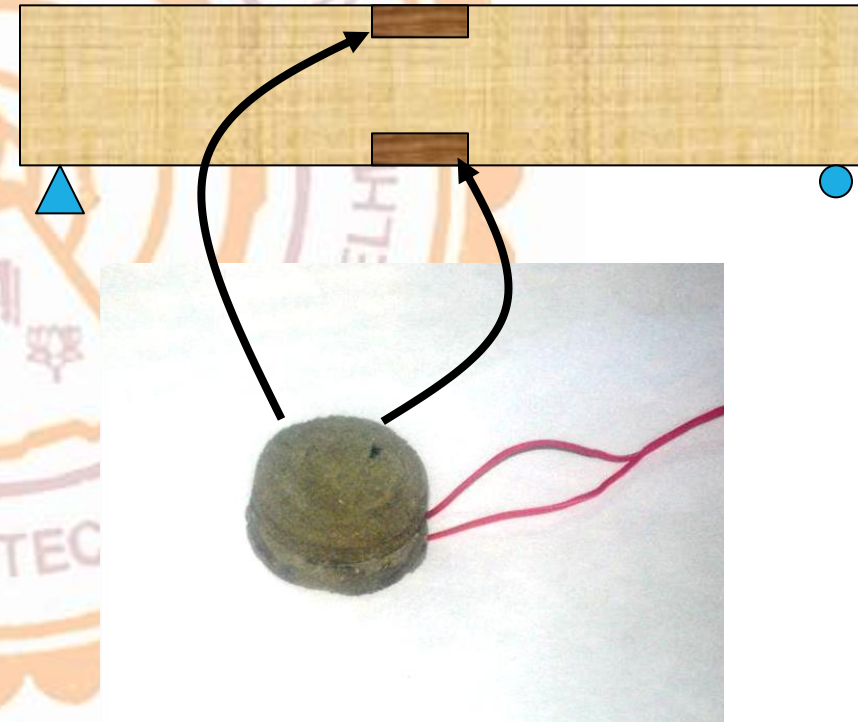
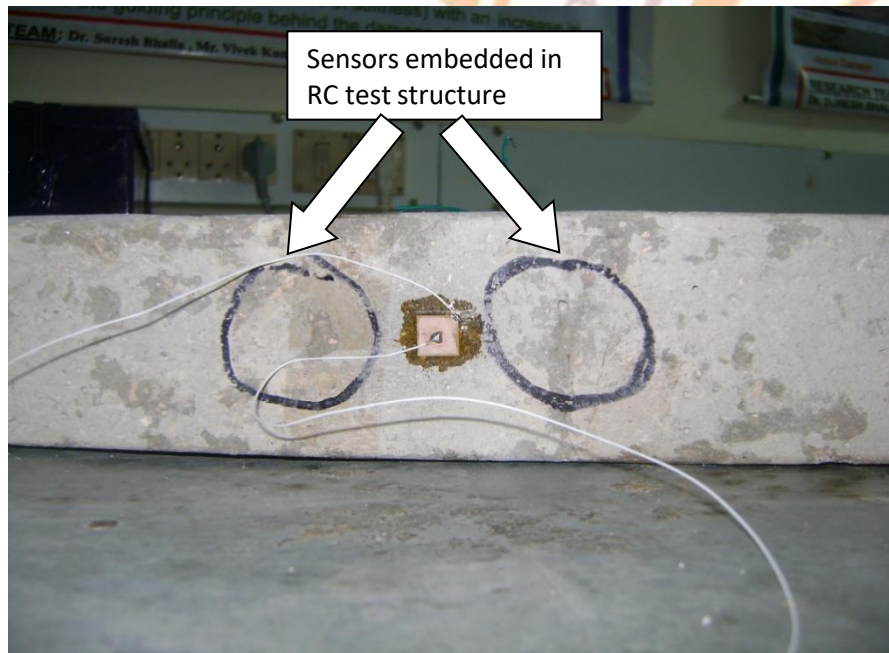
Agilent Technologies

64 channels, 3Mega samples per second per channel IMPORTED

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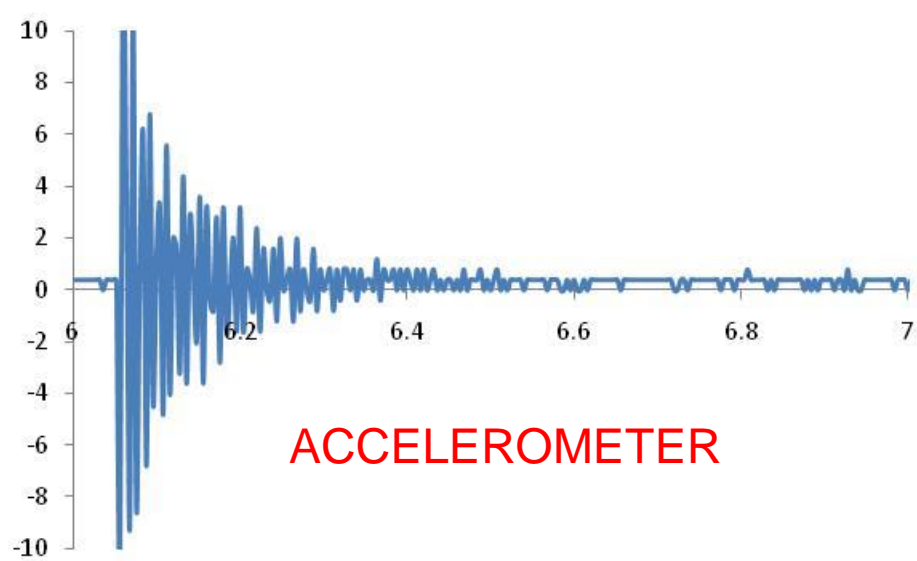
CONCRETE VIBRATION SENSOR (CVS)

CVS is a ready to use packaged sensor for dynamic response measurement developed especially for reinforced concrete (RC) structures such as buildings and bridges.

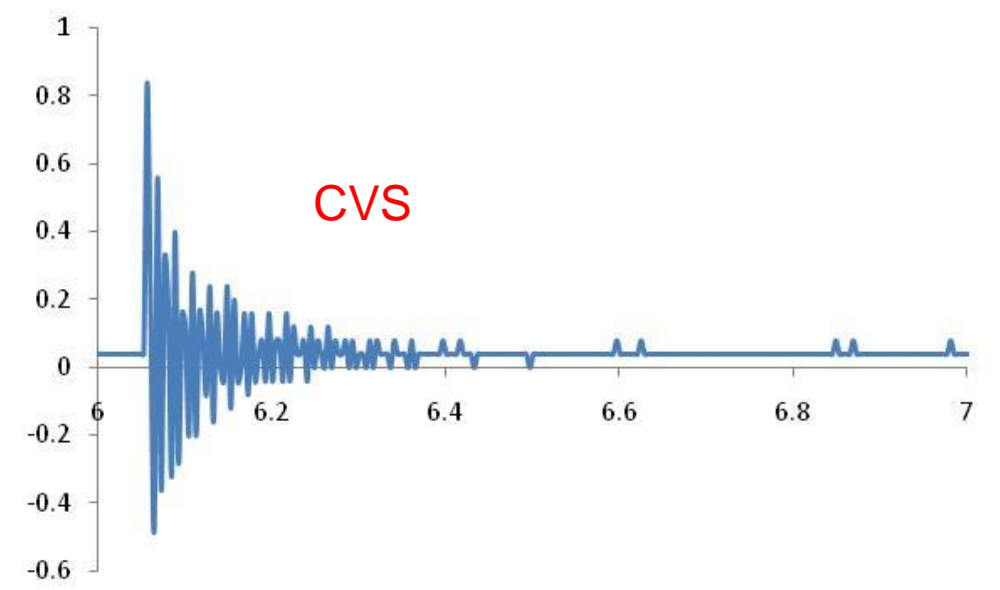


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ACCELEROMETER



CVS

KEY STRONG POINTS OF CVS

- ❑ Excellent signal to noise ratio
- ❑ Special encapsulation of the sensing element to prevent damage during casting.
- ❑ Higher longevity, negligible decay of the sensing element.
- ❑ Low cost (~ one-tenth of the cost of accelerometer)
- ❑ Miniature size
- ❑ No frequency bandwidth limitation



SYNOPSIS OF COURSE COVERAGE

ANSWERS EXPECTED FROM SHM

Has any damage occurred in the structure after its construction?

If yes, what is damage location?

If damage has occurred, how severe is it?

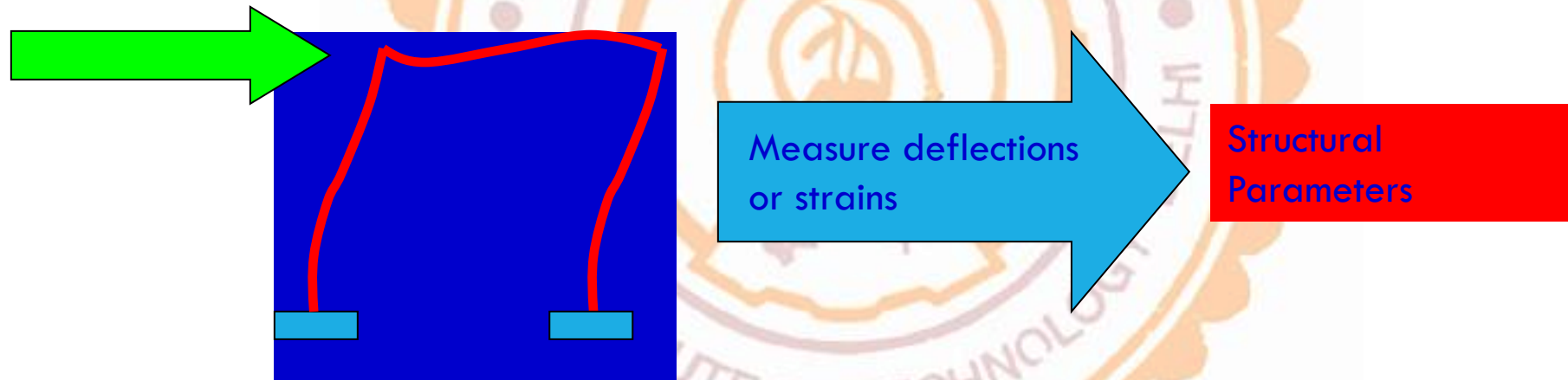
If damage has occurred, can the structure be still used? What is its remaining life?

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GLOBAL SHM TECHNIQUES

(1) *Static Response Based Techniques*

- Static Displacement Response (Banan & Hjelmstad, 1994)
- Static Strain Response (Sanayei & Saletnik, 1996)

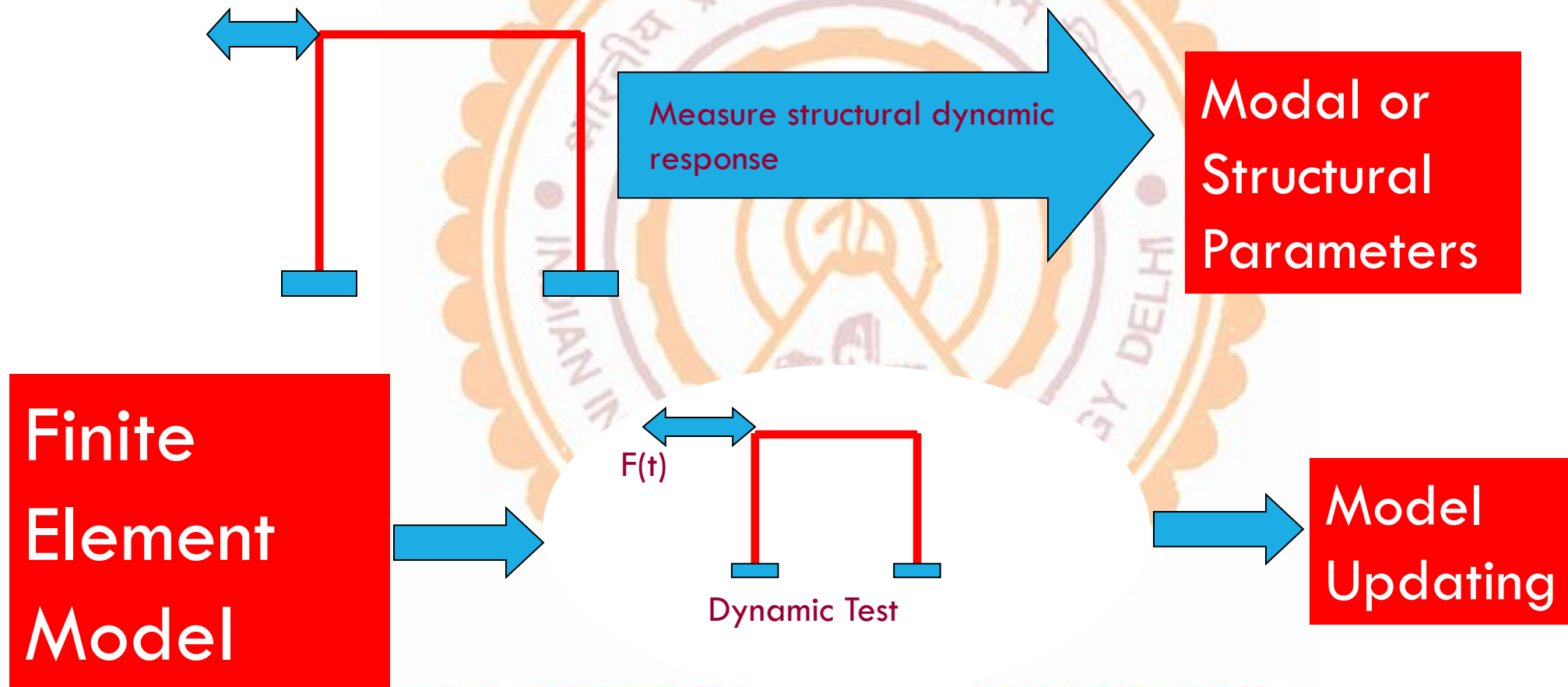


Time consuming => Cannot Enable Quick Assessment of Health.

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GLOBAL SHM TECHNIQUES

(2) Dynamic Response Based Techniques



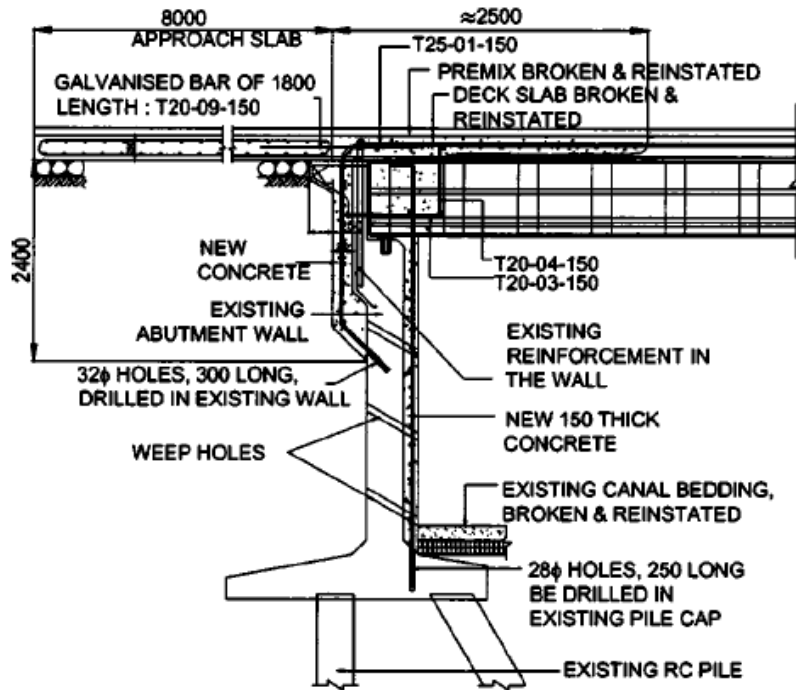
PIONEER BRIDGE- SINGAPORE



BROWNJOHN ET AL. (2003)



RETROFITTING was carried out to convert the simply supported system into a continuous deck monolithic with supports



How to make sure that retrofitting works were successful???

ANSWER:
Through inspection

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MODEL UPDATING OF PIONEER BRIDGE

Model updating was conducted for the bridge before and after upgrading based on experimental modal analysis of pre- and post-upgrade dynamic response. The bridge was modelled using 3D beam elements.

MAJOR OBSERVATIONS

- ★ To reflect the structural change in the upgrading, the abutment restraints were modelled as rotational springs of finite stiffness. The rotational stiffness at the abutments was found to be about 108N.m/rad after upgrading.
- ★ These investigations showed that bridge stiffness considerably increased due to the upgrading. This is evident from the increase of first natural frequency from about 6Hz to approximately 8 Hz.

GLOBAL SHM TECHNIQUES

Some features.....

- Practical, capable of quick assessment of health for simple structures.
- However, rely on first few modes only- Global modes.
- Hence, insensitive to local or incipient damages.

NDE TECHNIQUES (LOCAL)

Best when damage location be known a-priori

May render the structure unavailable during interrogation

Suitable for specific applications

SHM BY PZT PATCHES

Two modes

- (a) Dynamic strain sensor**
Direct effect, low-frequency
- (b) Electro-mechanical impedance (EMI) sensor**
Direct+ converse effect, high-frequency

ELECTRO-MECHANICAL IMPEDANCE (EMI) TECHNIQUE

Interface between global dynamic techniques and local NDE techniques

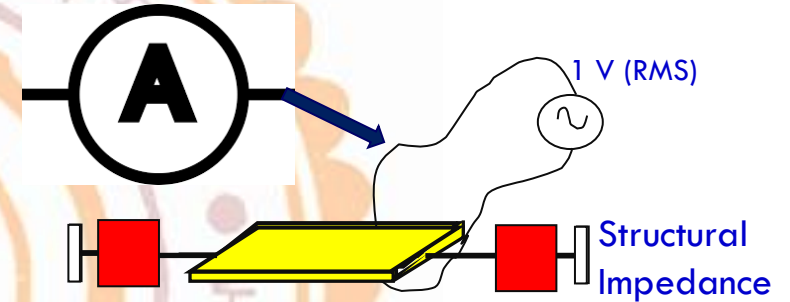
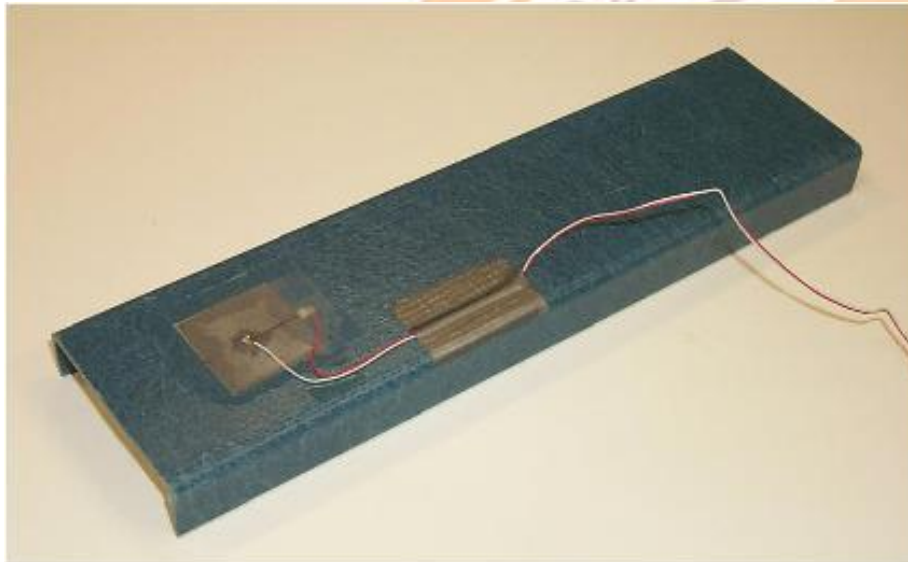
Principle = Similar to global vibration techniques
(Frequency employed: 30-400 kHz)

Sensitivity = As high as local ultrasonic (NDE)
technique

Piezoelectric materials are the key elements of EMI technique

ELECTRO-MECHANICAL IMPEDANCE (EMI) TECHNIQUE

A PZT patch is surface bonded on a structure using high strength adhesive and excited at high frequency (30-400 kHz) by an LCR meter or impedance analyzer (in sweep mode).



A simple physical model of system (Liang et. al, 1994)

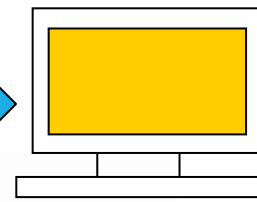
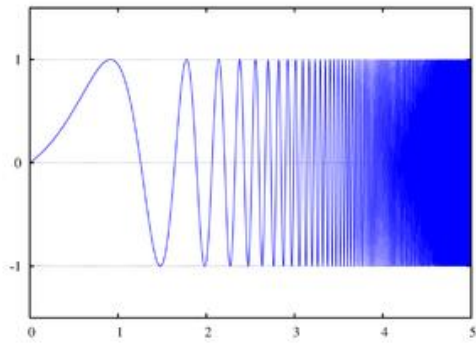
$$\bar{Y} = \frac{I_o e^{j(\omega t - \phi)}}{V_o e^{j\omega t}} = I_o e^{-j\phi} = G + Bj$$

G: Conductance, B: Susceptance

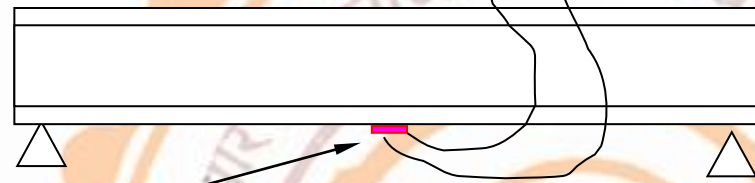
PZT PATCH ACTS AS SENSOR AND ACTUATOR SIMULTANEOUSLY.

The technique was originally developed for aerospace structures.

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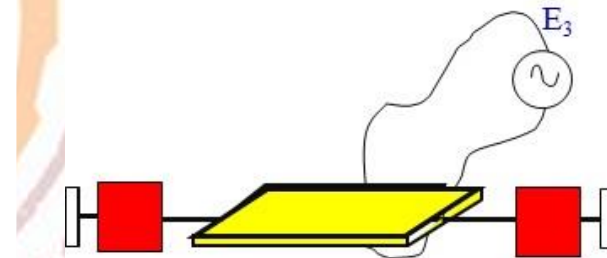
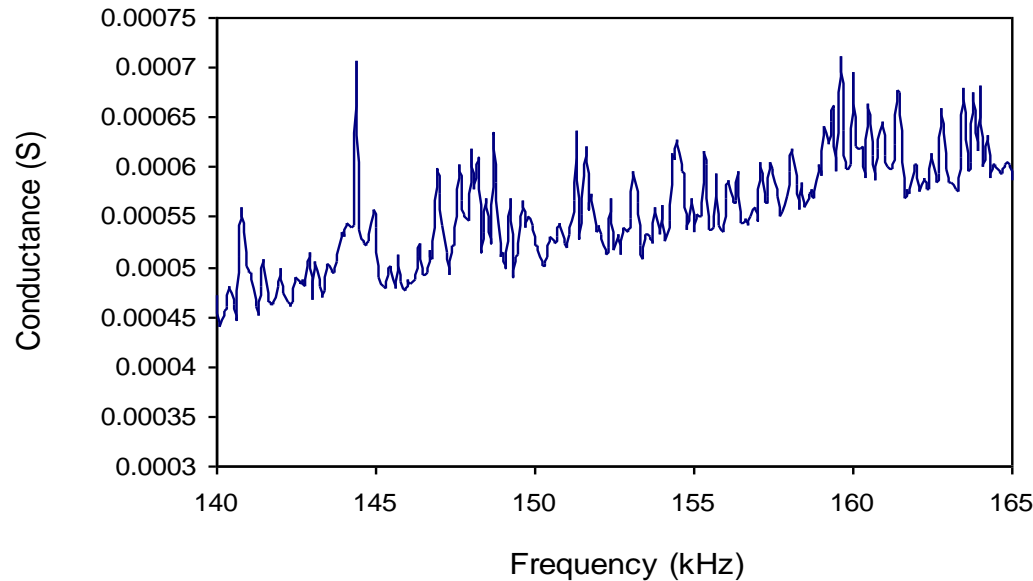


Structure



PZT patch

Admittance measurements at multiple frequencies form "signature"

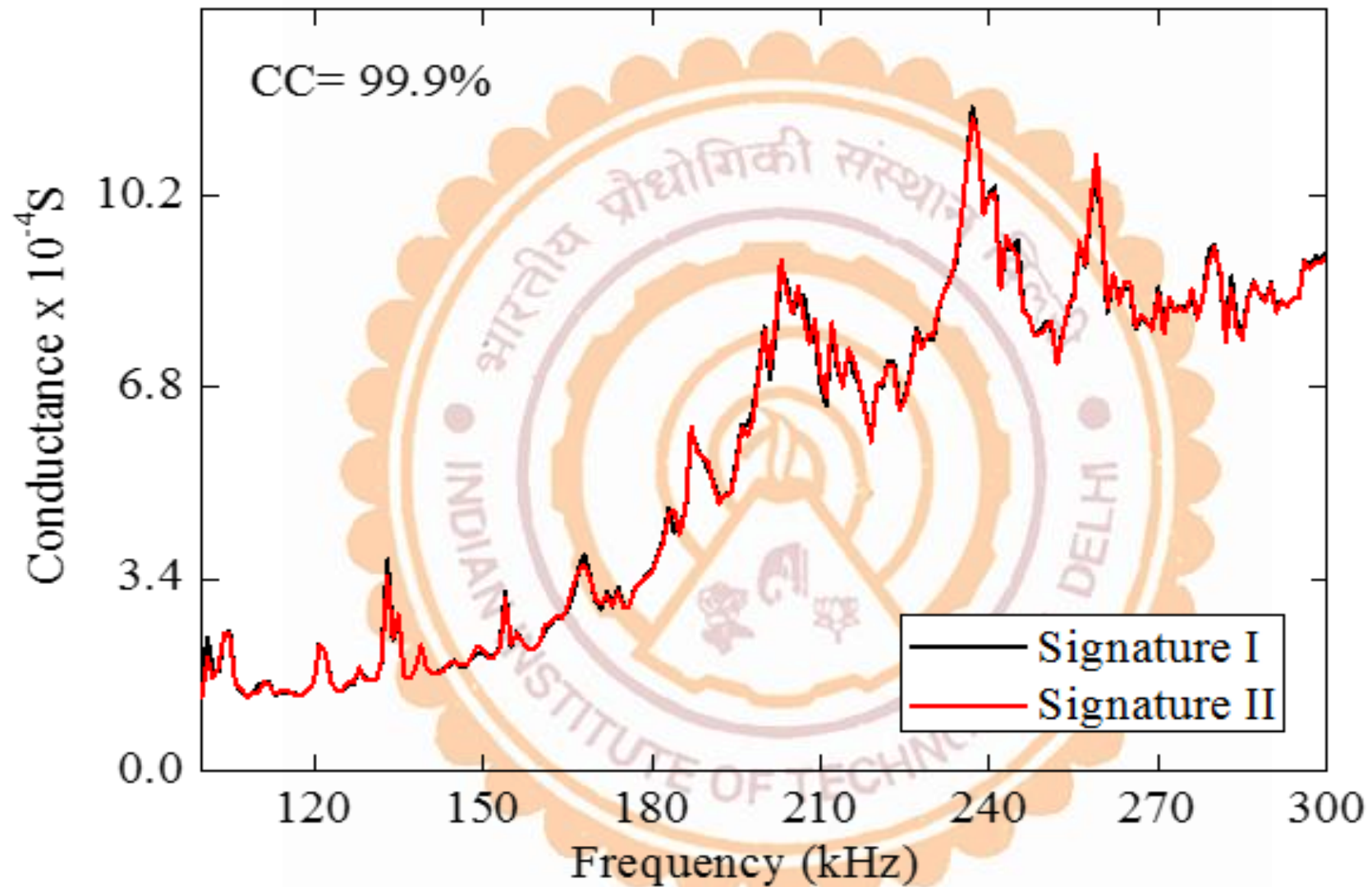


Structural Impedance

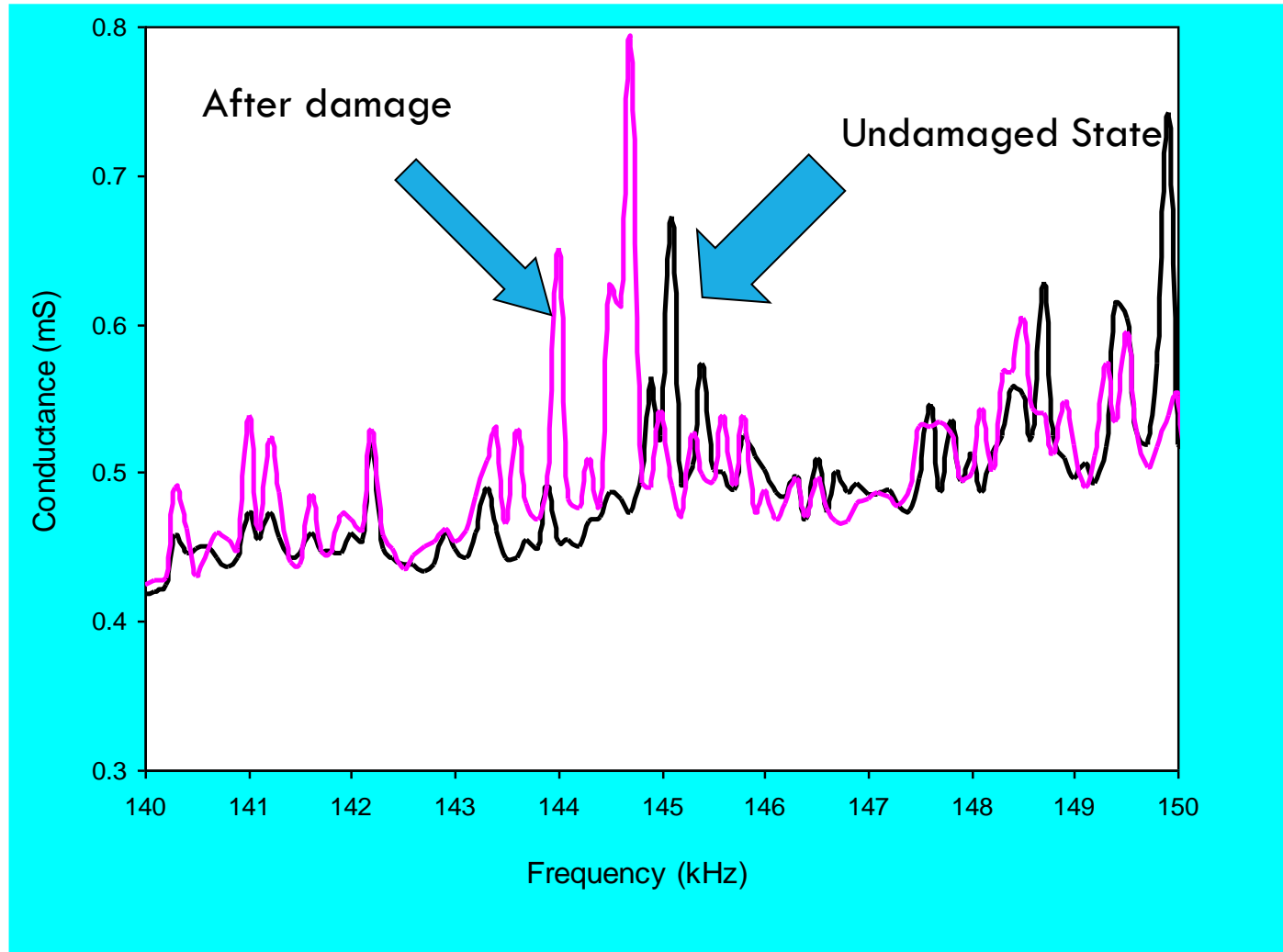
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NO CHANGE IN SIGNATURE IMPLIES.....

NO OCCURRENCE OF DAMAGE IN THE STRUCTURE



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ADVANTAGES OF PIEZO-IMPEDANCE TRANSDUCERS

- * **LOW COST**
- * Fast dynamic response, long term durability, competitive performance, negligible ageing
- * High sensitivity (comparable to ultrasonic techniques)
- * Same PZT patch can also be used to measure dynamic strain.....No frequency limitation (0.5Hz to few MHz).
- * Immunity to ambient noise (EMI Technique)....Why?

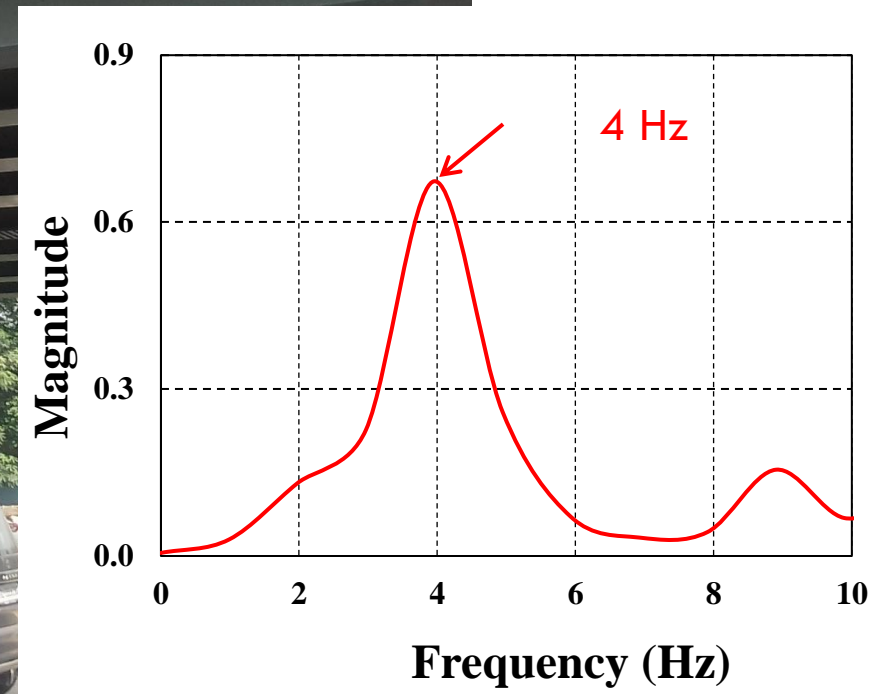
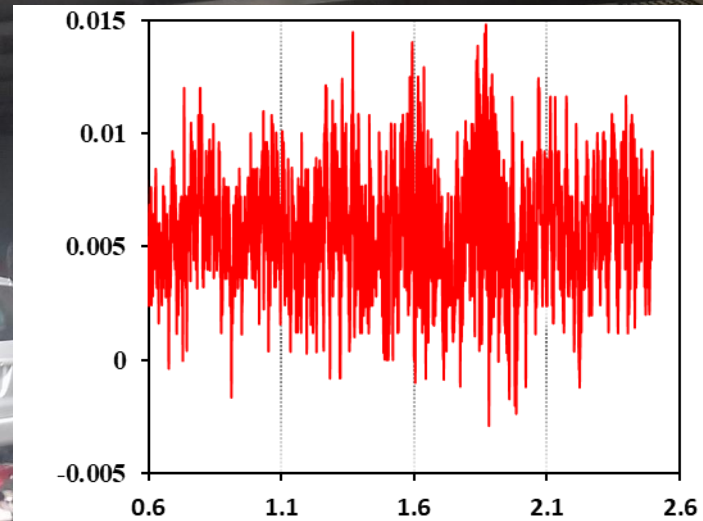
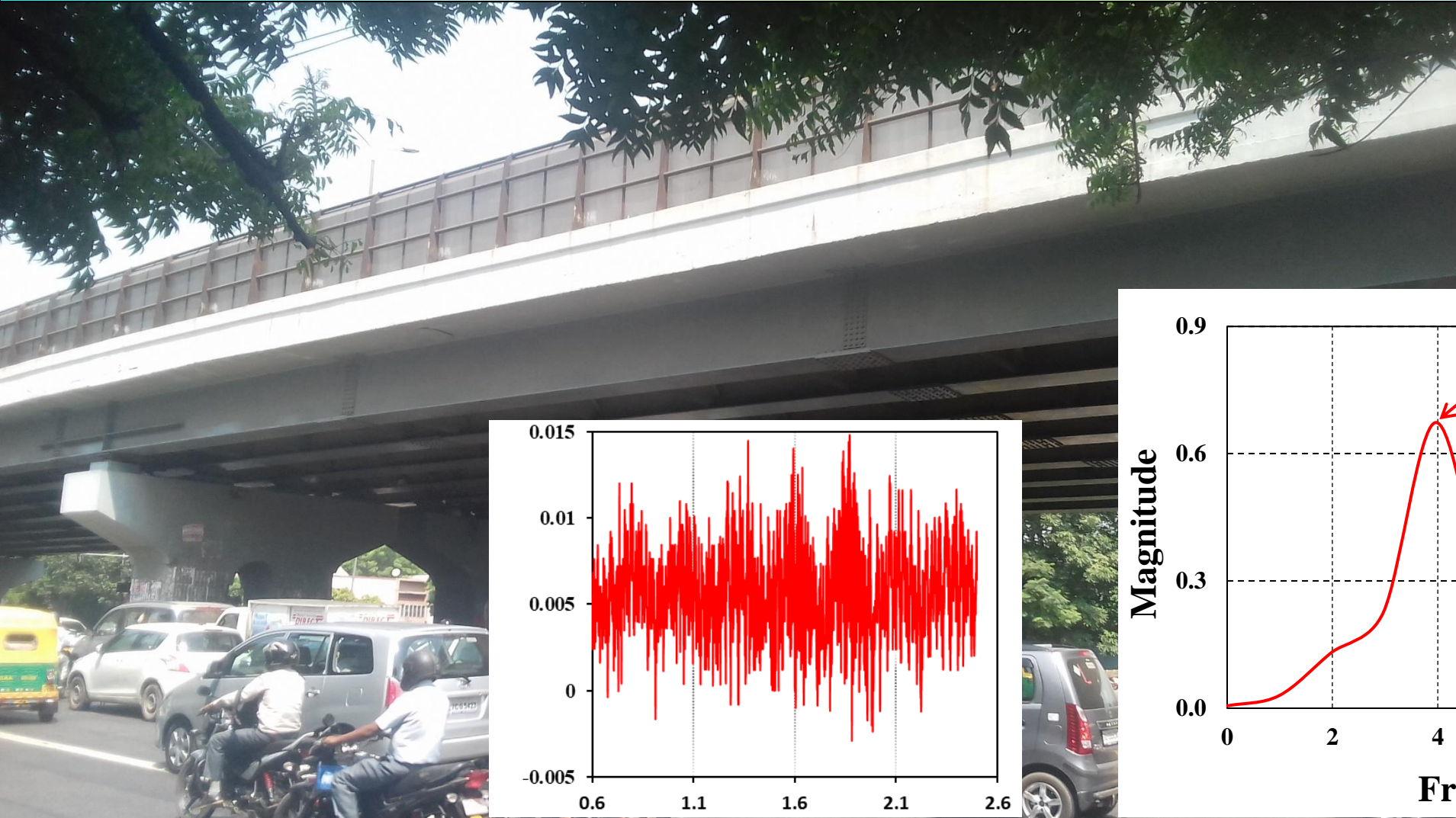
ENERGY HARVESTING




IDTECHEX (2009)

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REAL-LIFE APPLICATION



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Piezo patch

Cantilever

The background features a large, semi-transparent watermark of the IIT Delhi logo. The logo is circular with a scalloped edge and contains the text 'भारतीय प्रौद्योगिकी संस्थान दिल्ली' (Indian Institute of Technology Delhi) in Hindi and 'INDIAN INSTITUTE OF TECHNOLOGY DELHI' in English.

THANK YOU

**SUGGESTED READING:
BHALLA ET AL. (2005)
(TUNNELLING & UNDERGROUND
SPACE TECHNOLOGY)**